

Probing the underlying physics of nanoelectronics with Raman spectroscopy

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New Group Formed at NIST



Lead by Curt Richter

NANOELECTRONICS GROUP (683.04)

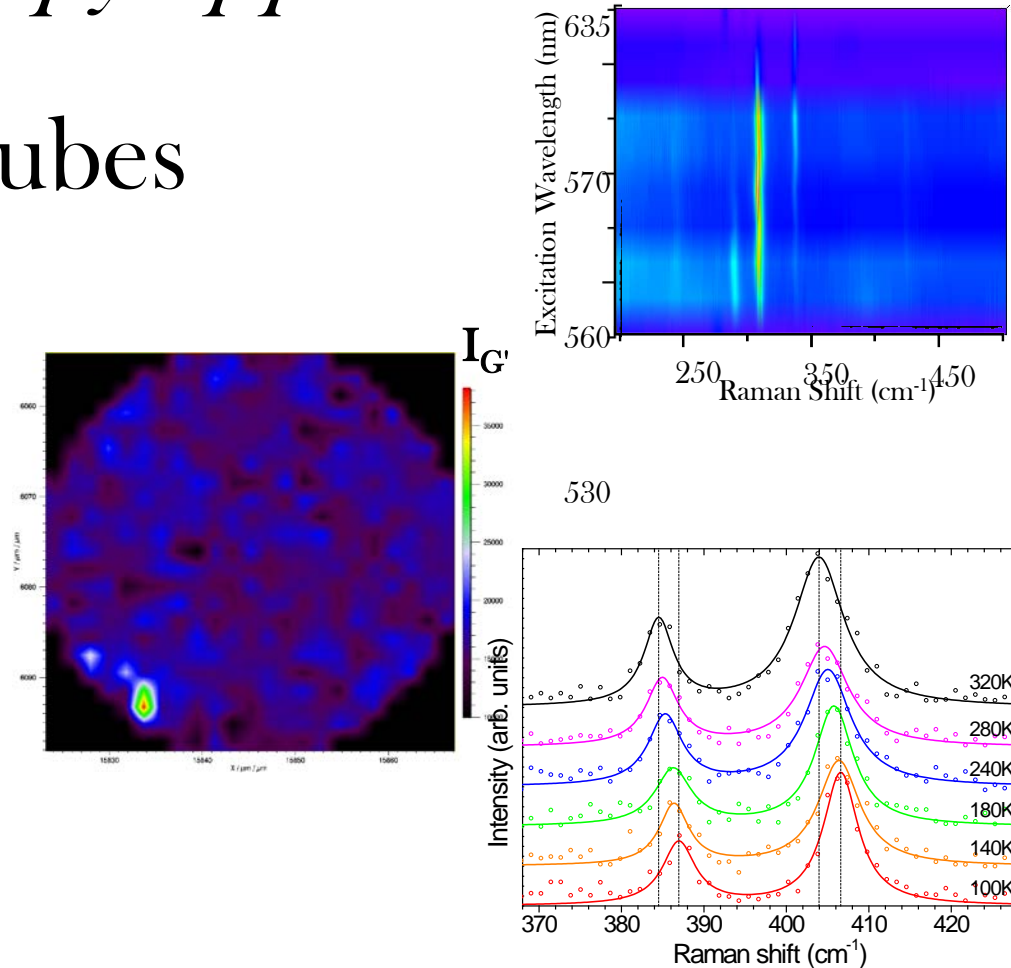
Conducts basic research to advance the optical and electrical measurement science infrastructure necessary for innovation in future nanoelectronic and thin-film devices, and their component materials.

- **Pushes the frontiers of optical spectroscopies** (e.g., Raman spectroscopy, spectroscopic ellipsometry, and infrared spectroscopy) **and electrical measurements** (e.g., magnetotransport, nanoelectronic test structure development, and temperature dependent current-voltage spectroscopy)
- **Develops and advances novel measurements that combine and correlate optical and electrical methods** such as internal photoemission, magneto-optical spectroscopy, and transient photocurrent spectroscopy.

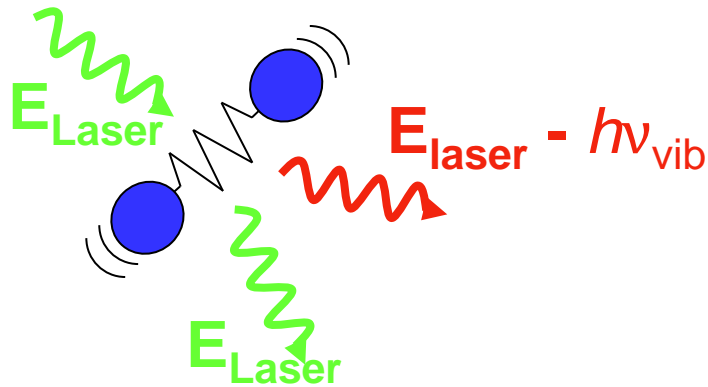
Outline

Raman spectroscopy applied to

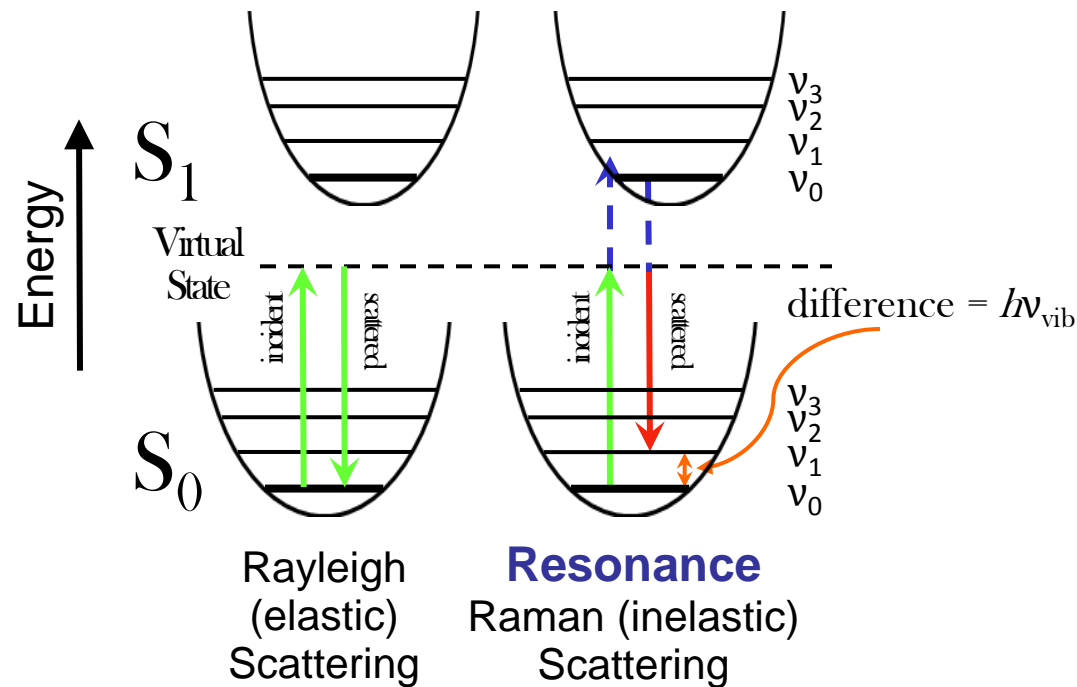
- Carbon Nanotubes
- 2D Materials
- Graphene
- MoS₂



The Raman Effect: Inelastic Scattering



- Rapid
- Highly specific
- Non-destructive
- Rich
 - Layer number and orientation
 - Defects/Edges
 - Electron Phonon coupling
 - Temperature
 - Doping
 - Strain
 - Crystallographic orientation
 - Chemical functionalization

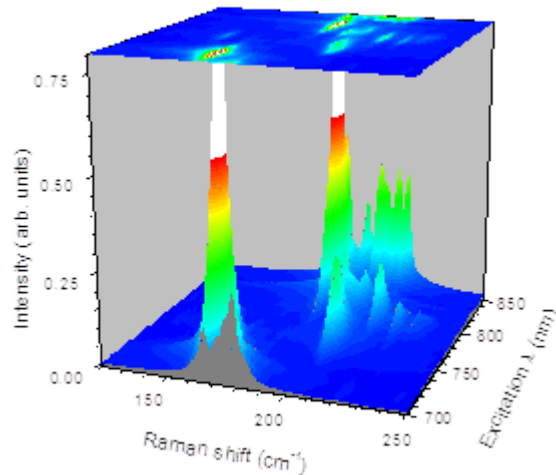
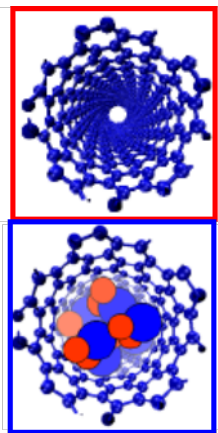
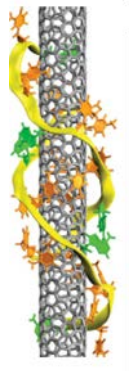
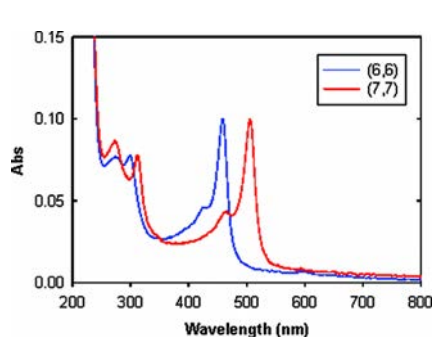


Novel Measurement Methods

- Techniques enhanced by presence of the nano-object
- Very sensitive to carbon nanostructures, i.e. carbon nanotubes and graphene
- Unique capabilities spanning THz through NIR region

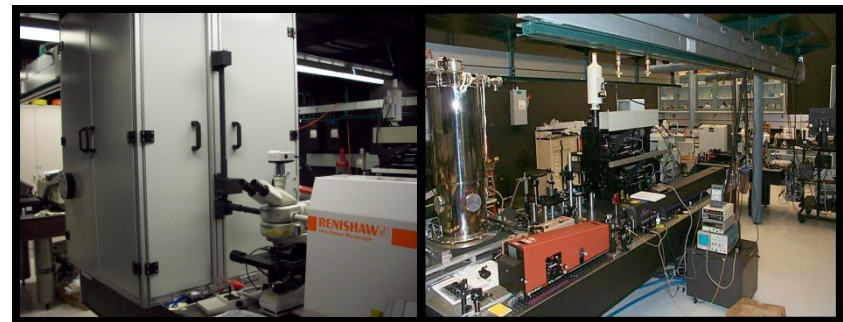
Expertise and Resources

- Raman Spectroscopy
 - Triple-grating XY-800
 - Renishaw InVia Microscope
- Laser fluorescence spectroscopy
- Combined AFM-Raman imaging
- Surface-enhanced Raman spectroscopy (SERS)
- Tip-enhanced Raman spectroscopy (TERS)
- Multiple laser excitation
 - Argon ion (multiple discrete lines), Ti:Sapphire (tunable), 633 nm HeNe, 785 nm diode, Dye lasers (tunable)
- Cryostats : 4 K - 400 K
- Environmental cell



ACS Nano 2011 5, 5 3943

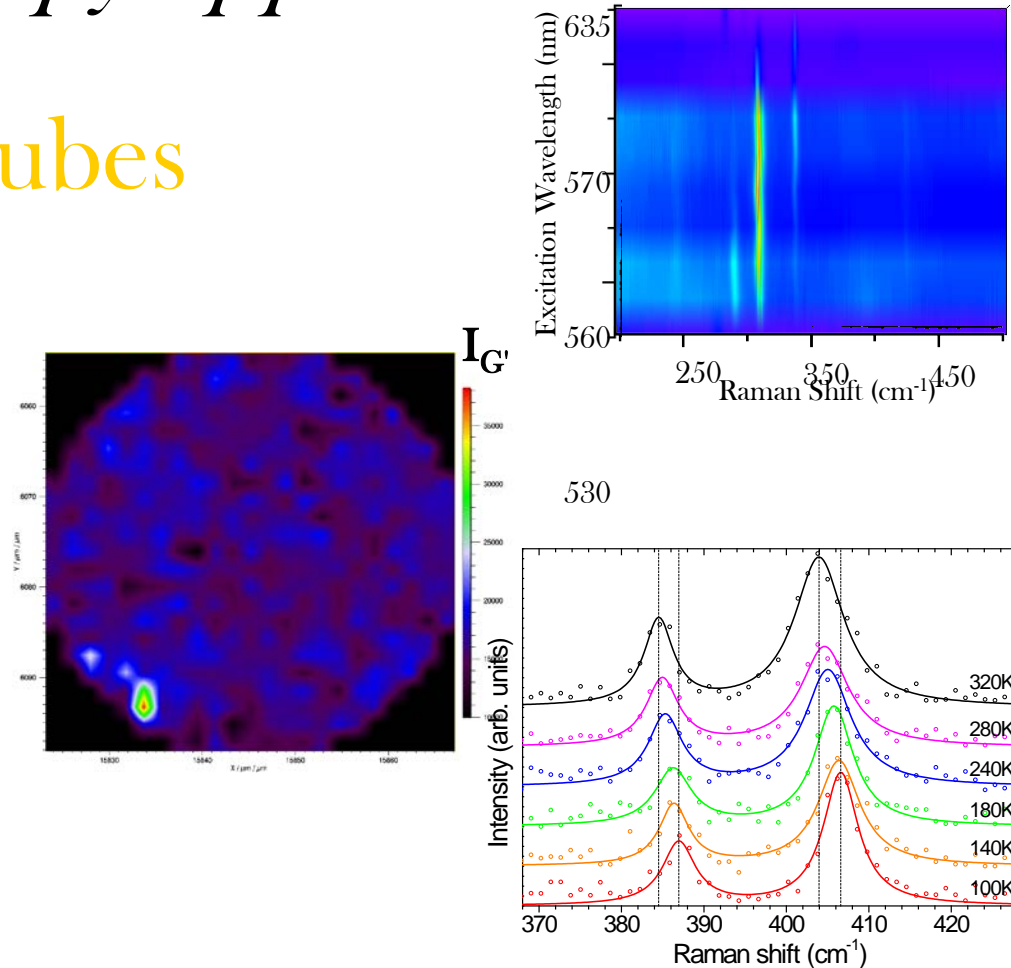
J. Am. Chem. Soc., 2011, 133 (33), pp 12998–13001



Outline

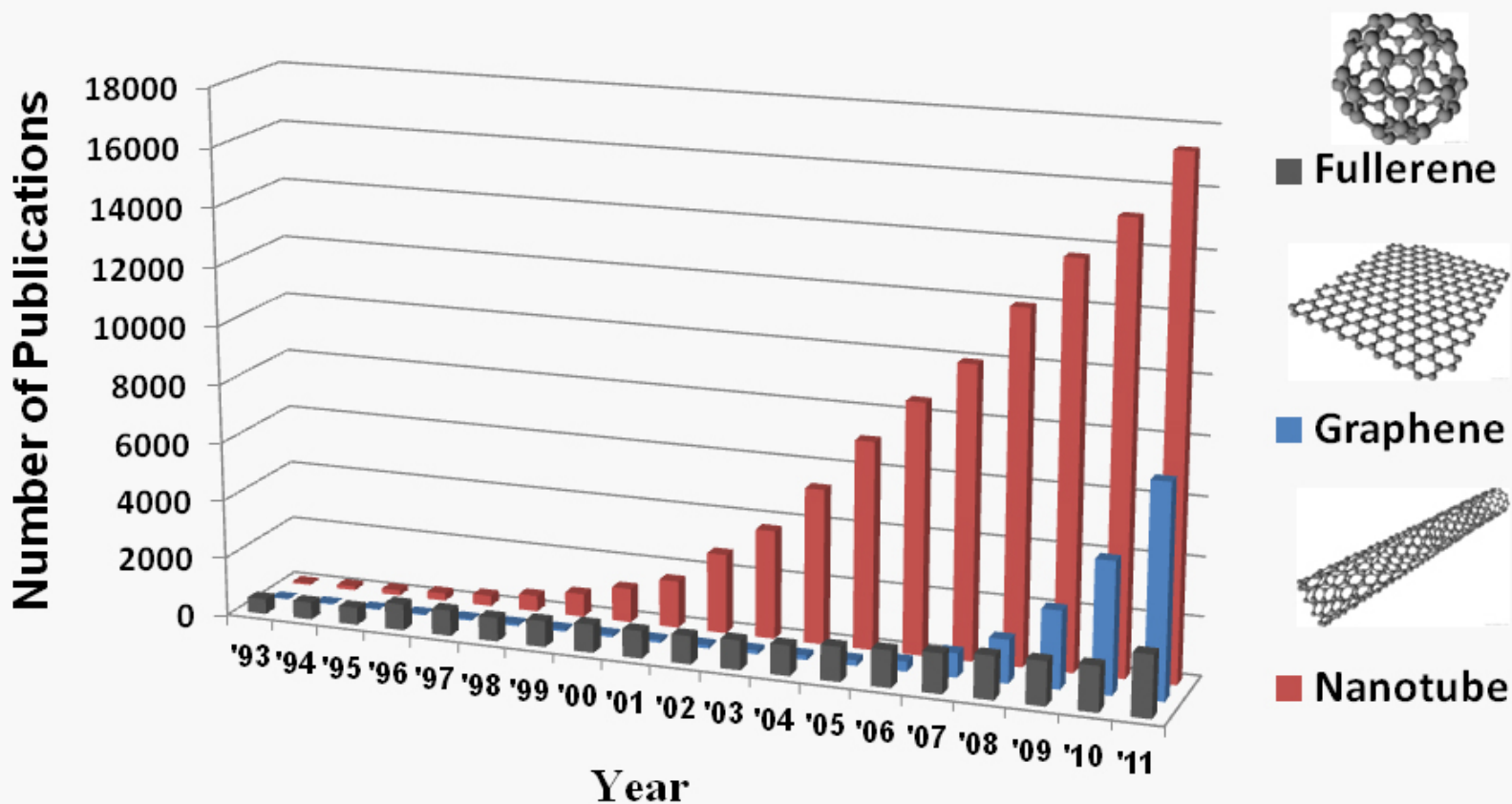
Raman spectroscopy applied to

- Carbon Nanotubes
- 2D Materials
 - Graphene
 - MoS₂

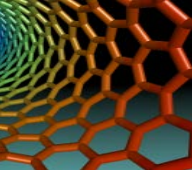


Publications per year

Slide used with permission from M. Dresselhaus APS 2013



Data extracted from the Web of Knowledge (Science Citation Index) searching for the words fullerene, nanotube, and graphene.



Nanoelectronics

nature
nanotechnology

LETTERS

PUBLISHED ONLINE: 28 OCTOBER 2012 | DOI: 10.1038/NNANO.2012.189

High-density integration of carbon nanotubes via chemical self-assembly

Hongsik Park*, Ali Afzali*, Shu-Jen Han, George S. Tulevski, Aaron D. Franklin, Jerry Tersoff, James B. Hannon and Wilfried Haensch

The New York Times Technology | Personal Tech | Business Day

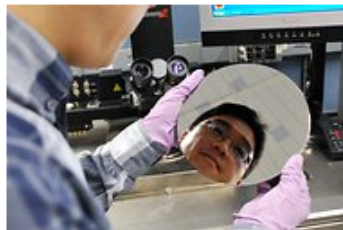
Bits

OCTOBER 28, 2012, 2:00 PM | 45 Comments

I.B.M. Reports Nanotube Chip Breakthrough

By JOHN MARKOFF

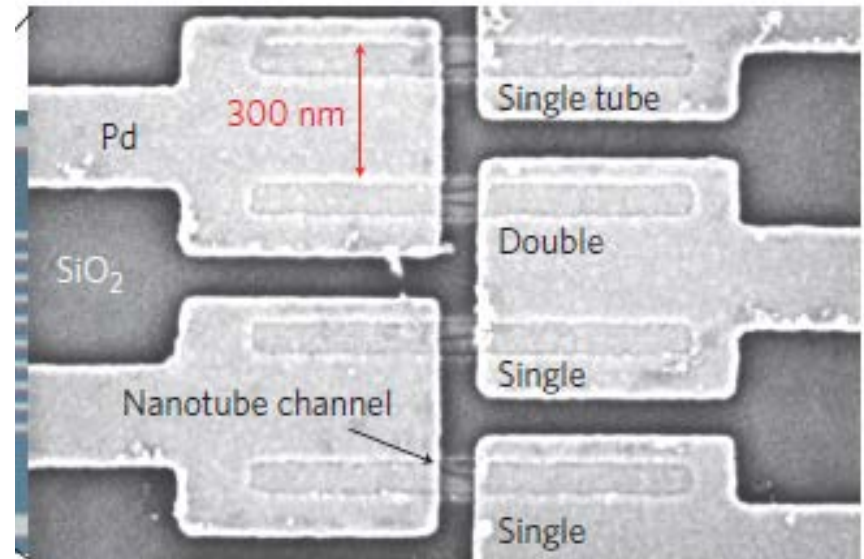
SAN FRANCISCO — I.B.M. scientists are reporting progress in a chip-making technology that is likely to ensure that the basic digital switch at the heart of modern microchips will continue to shrink for more than a decade.

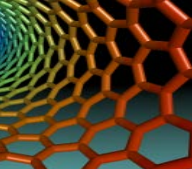


I.B.M. Research

The face of an I.B.M. research scientist, Hongsik Park, is reflected in a wafer used to make microprocessors.

The advance, first described in the journal Nature Nanotechnology on Sunday, is based on carbon nanotubes — exotic molecules that have long held out promise as an alternative to silicon from which to create the tiny logic gates now used by the billions to create microprocessors and memory

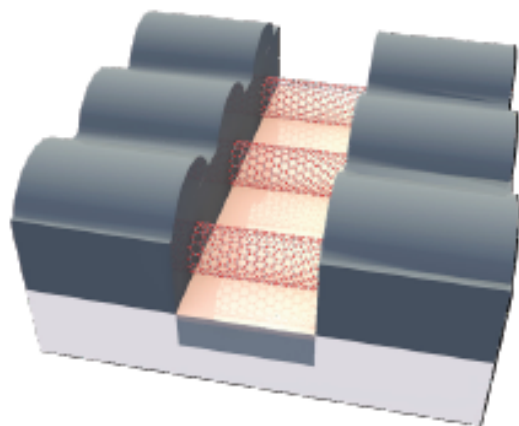




Recent Workshop

C Carbon Nano Tube Digital Electronics

WORKSHOP

**Purpose:**

To review and discuss the current status and potential benefits of carbon nanotubes in digital electronic applications.

Who will attend (Invitation only):

- Top researchers in the field from academia, government, and industry.
- Program managers and other colleagues from relevant government agencies.

Date:

Thursday, September 6, 2012

Location:

NIST
100 Bureau Drive
Gaithersburg, MD 20899

Registration:

http://www.nist.gov/pml/div683/cnt_workshop.cfm

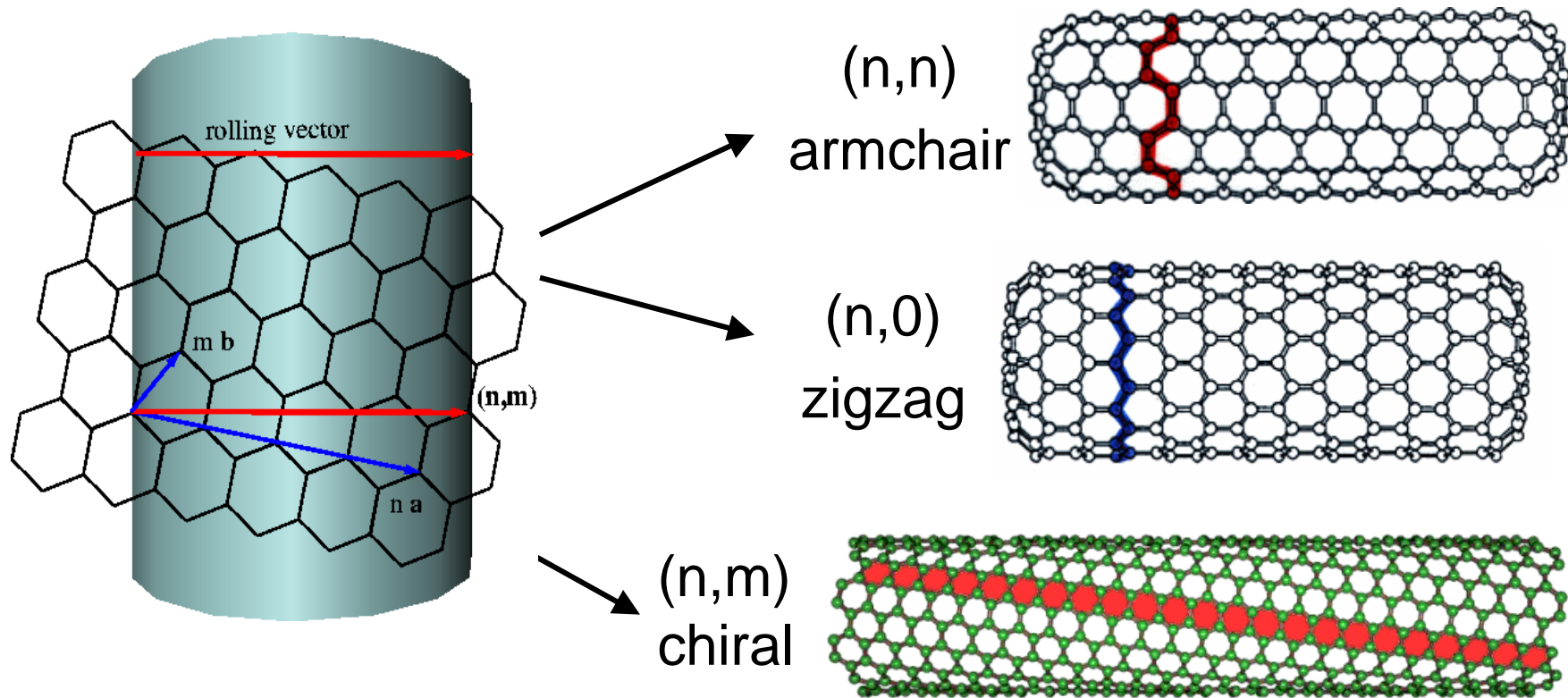
No registration fees

Coffee and lunch provided

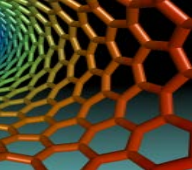
Lodging:

Block of rooms reserved for 9/5 and 9/6 at Hilton

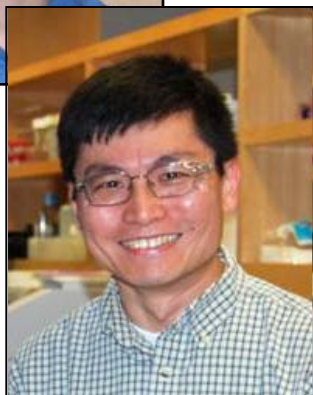
Single-Wall Carbon Nanotubes



Roll up vector determines physical properties, electronic nature and surface interactions.



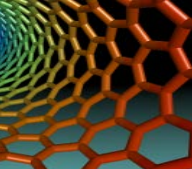
Fundamental Metrology for Carbon Nanotube Science and Technology



Identify the fundamental properties of the
nanomaterials



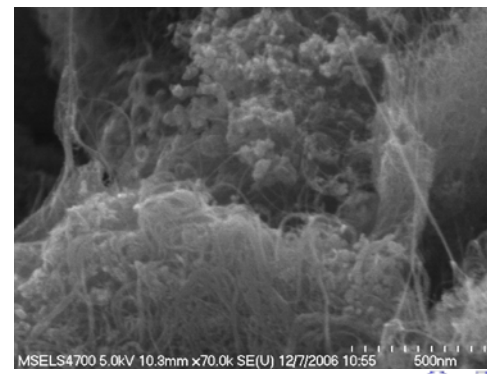
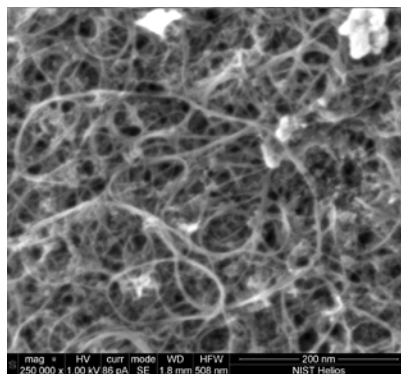
Isolate the nanomaterial for study



Polydispersity Problem

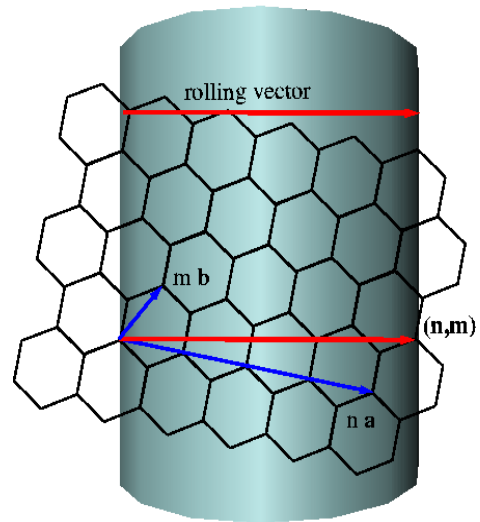
**ALL SAMPLES
are DIFFERENT**

**SWCNT length
distribution, powder
morphology,
impurity content all
vary batch to batch
(or even within a
batch) and across
manufacturers.**

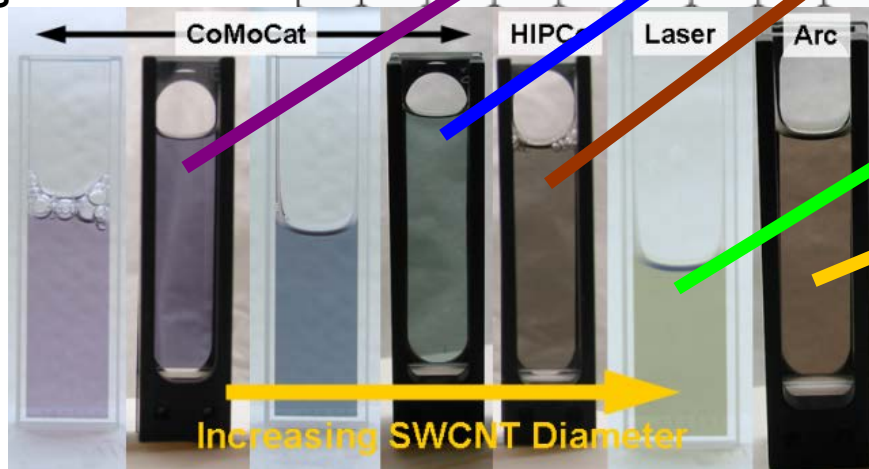
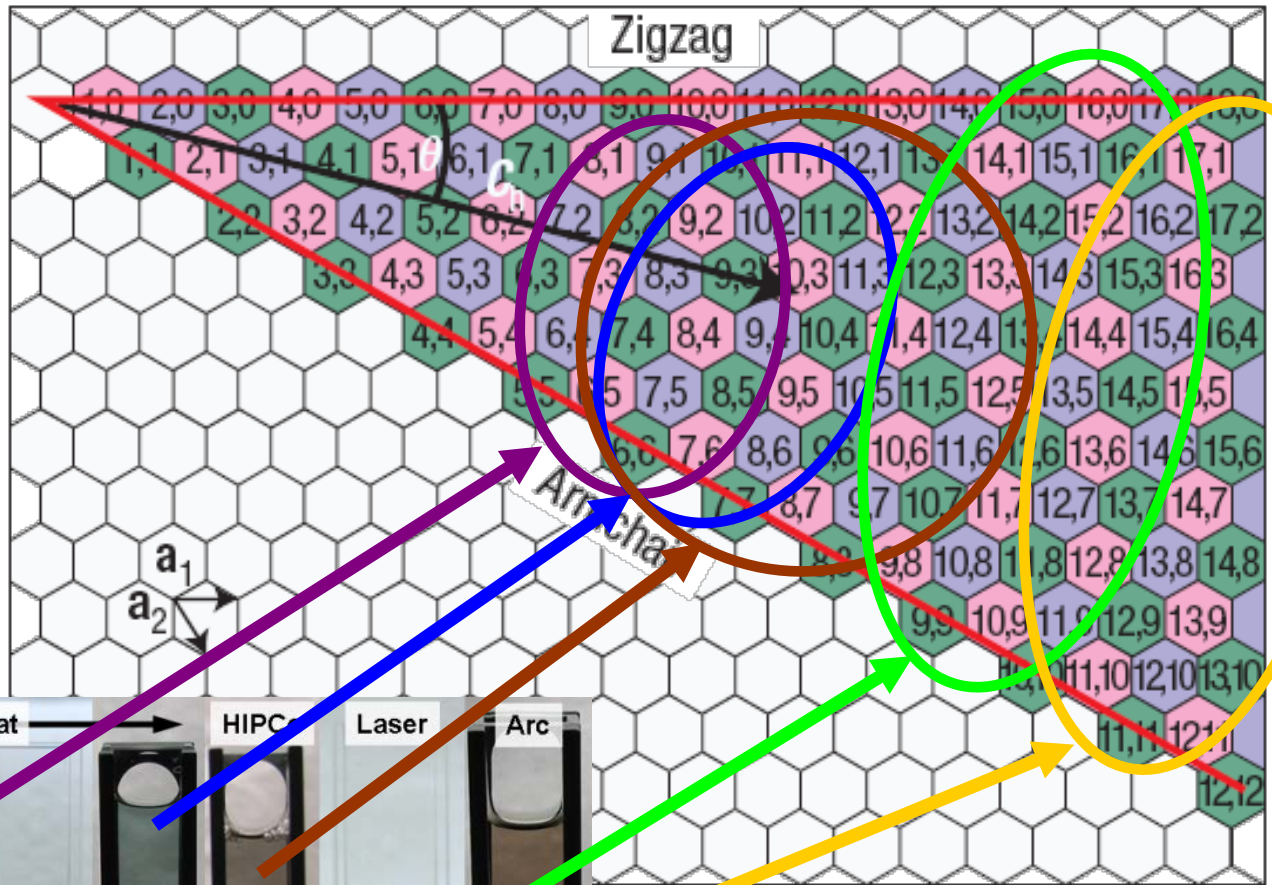


Polydispersity

Synthesis techniques produce varying SWCNT distributions

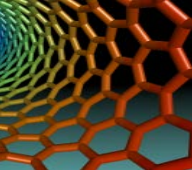


chiral vector determines physical properties



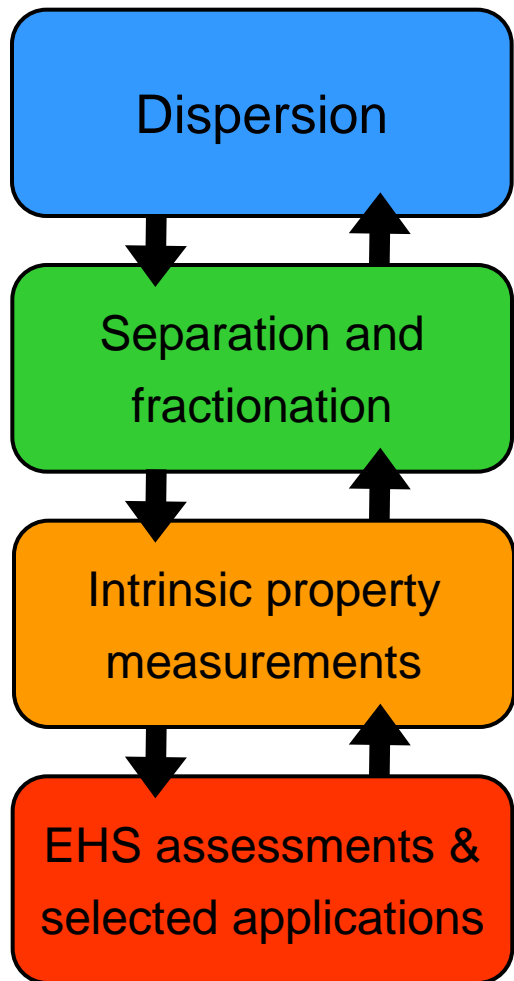
Hersam et al., Nature Nanotech 2008

green: metallic;
Pink, Purple: Semi-conducting

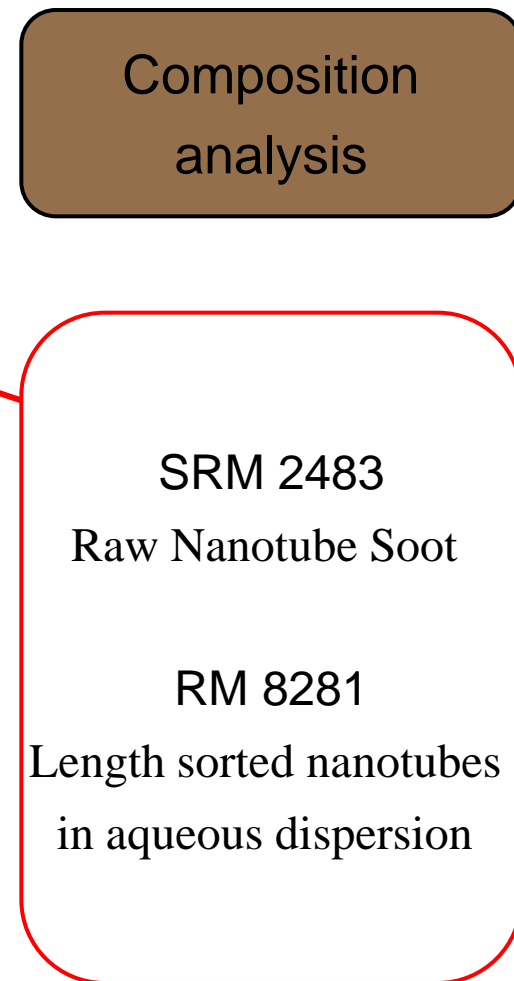


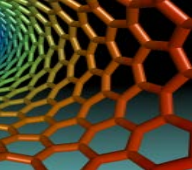
Nanotube Metrology Program

Liquid Phase



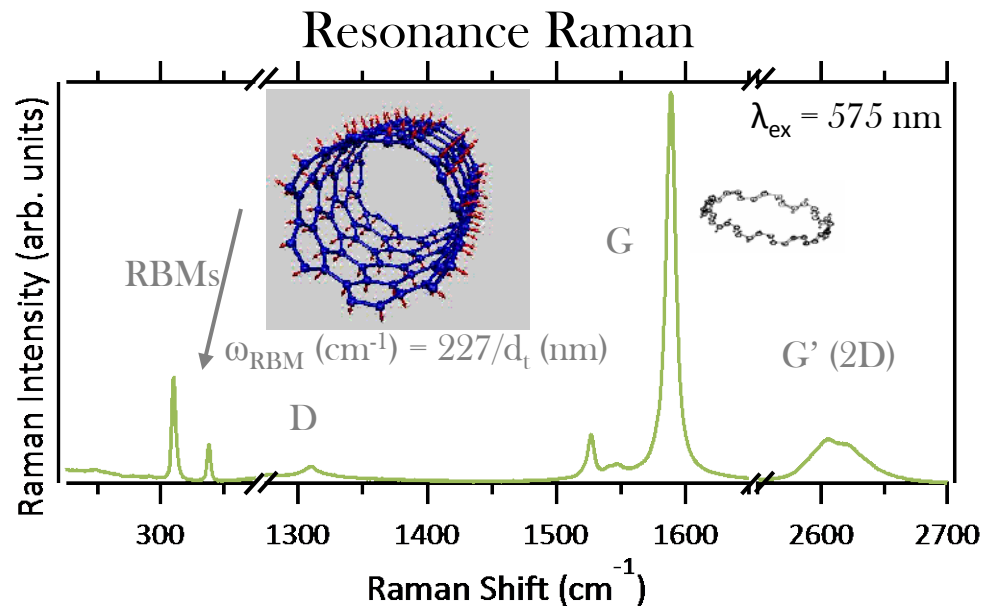
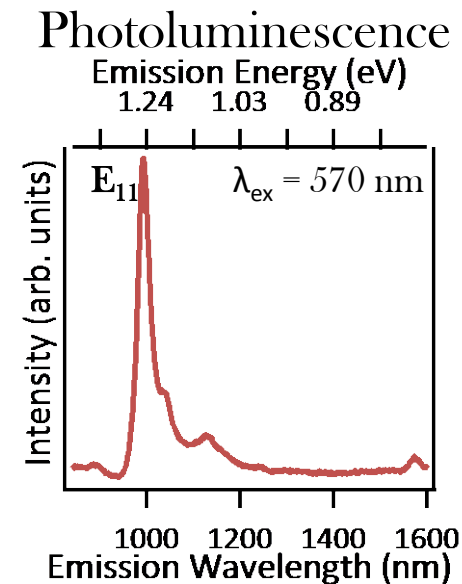
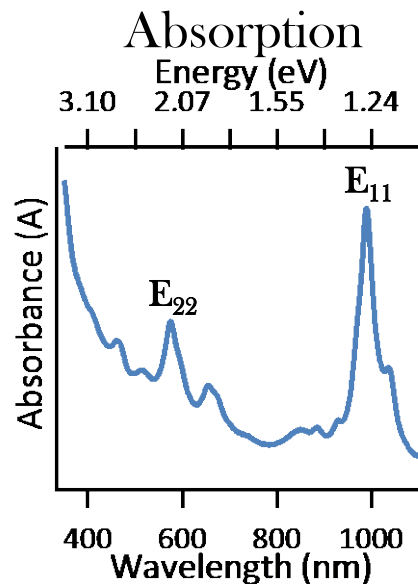
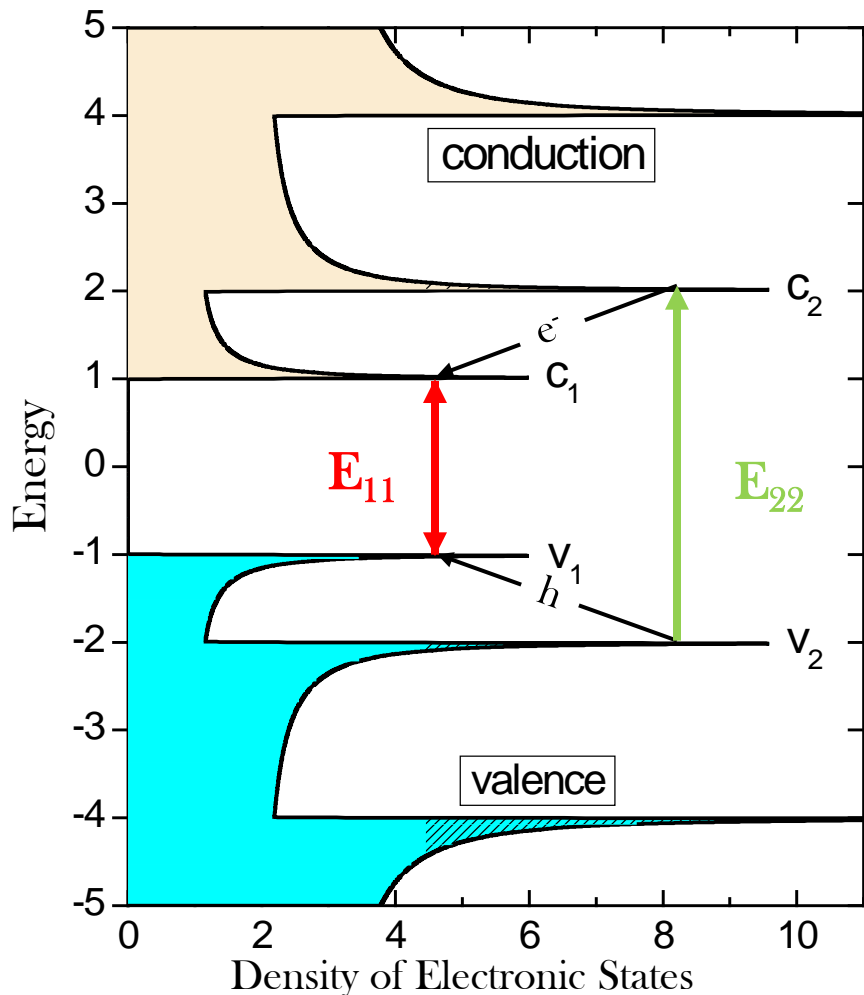
Solid Phase





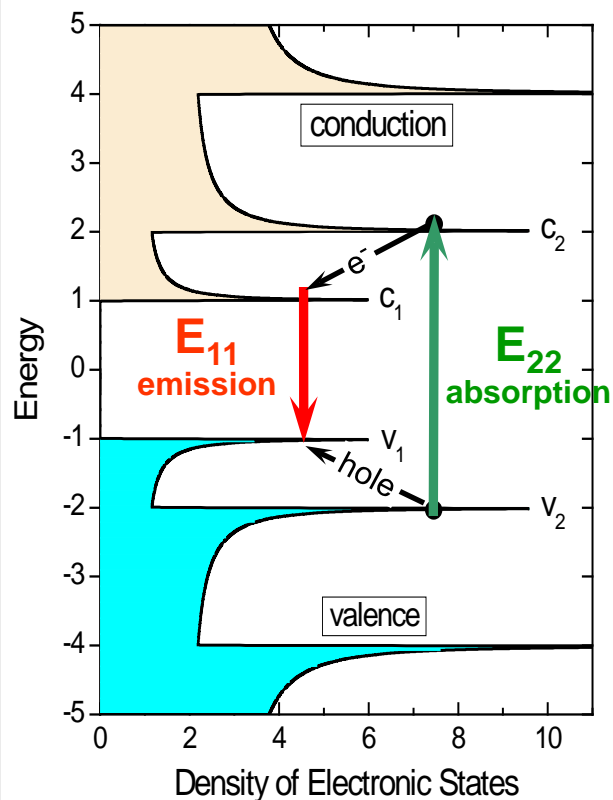
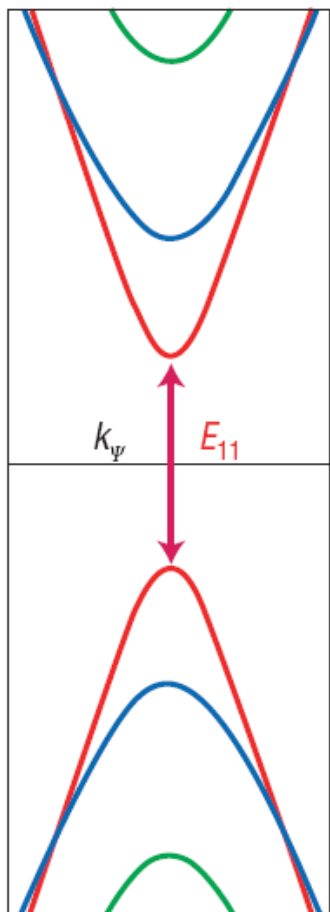
Optical Properties of SWCNTs

Optical properties of SWCNTs arise from van Hove singularities in 1-D density of states

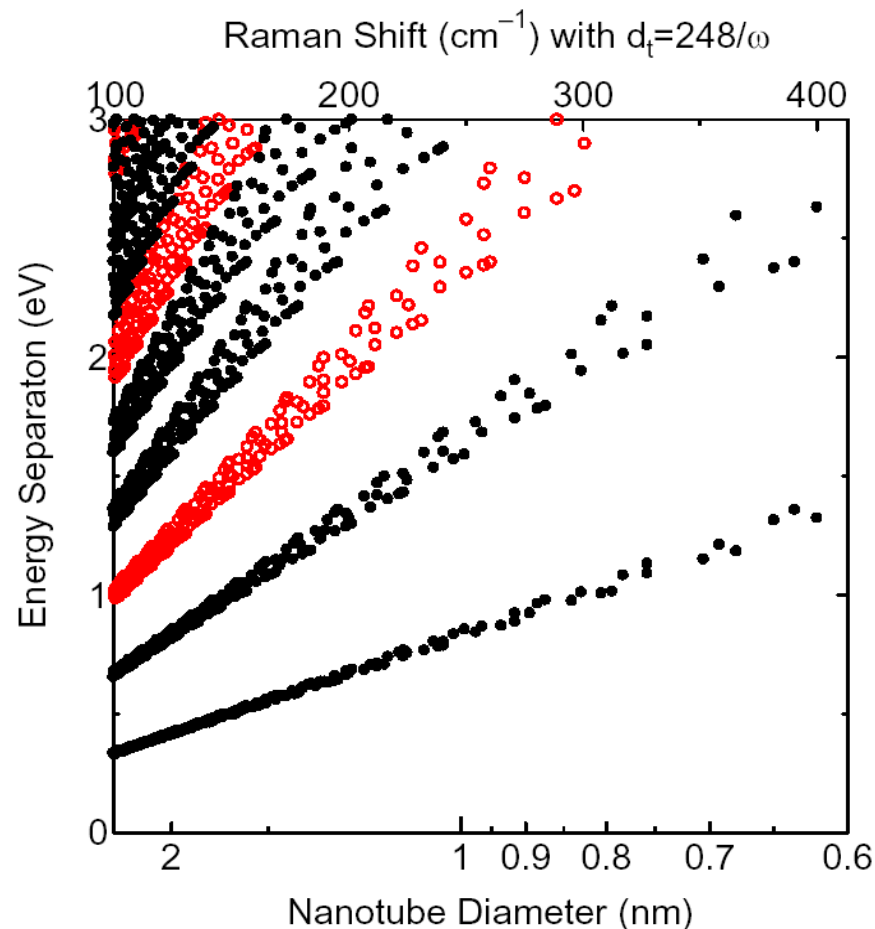


Electronic Structure of SWCNTs

1D Density of States – van Hove singularities

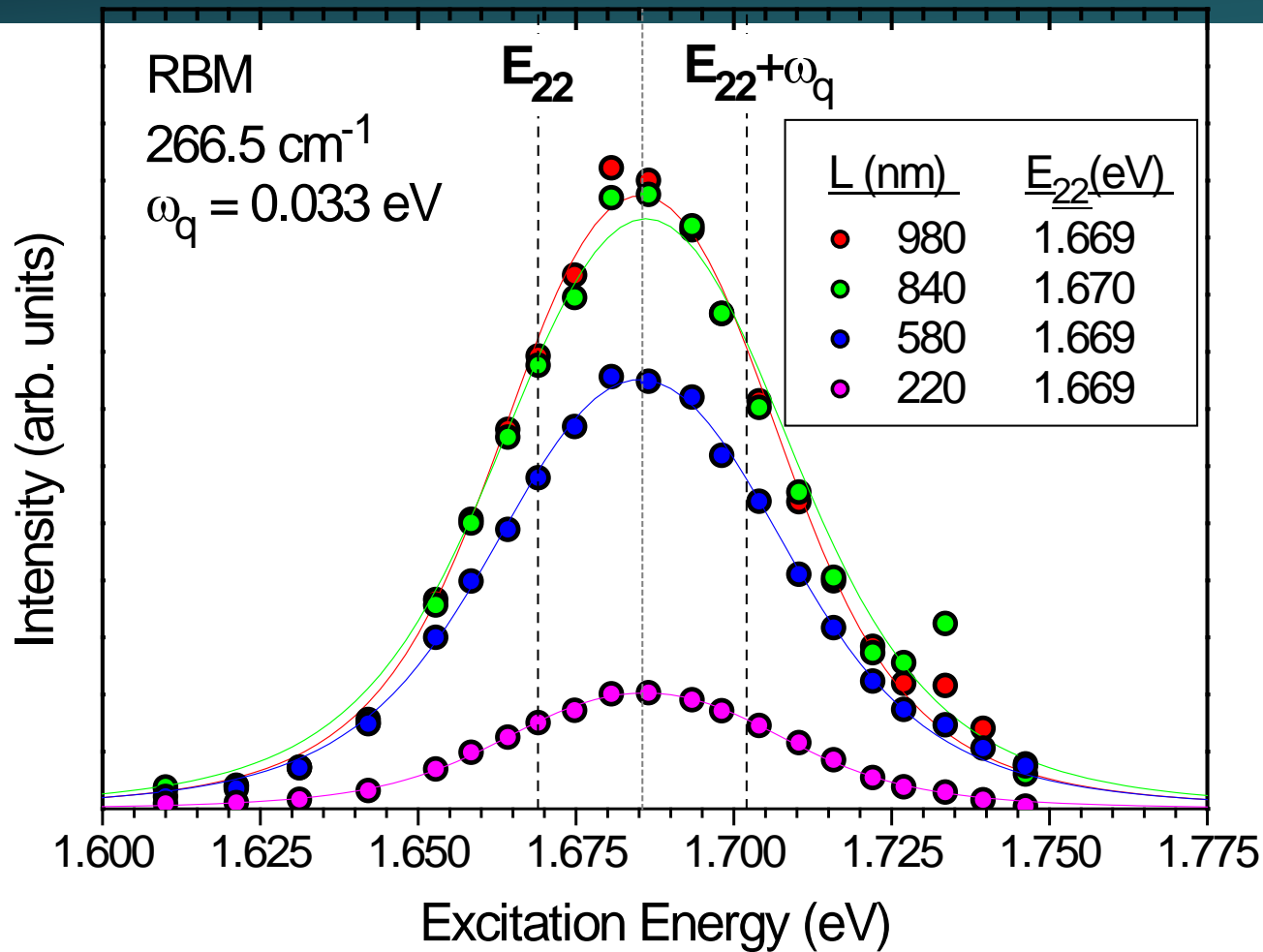


Katuara Plot



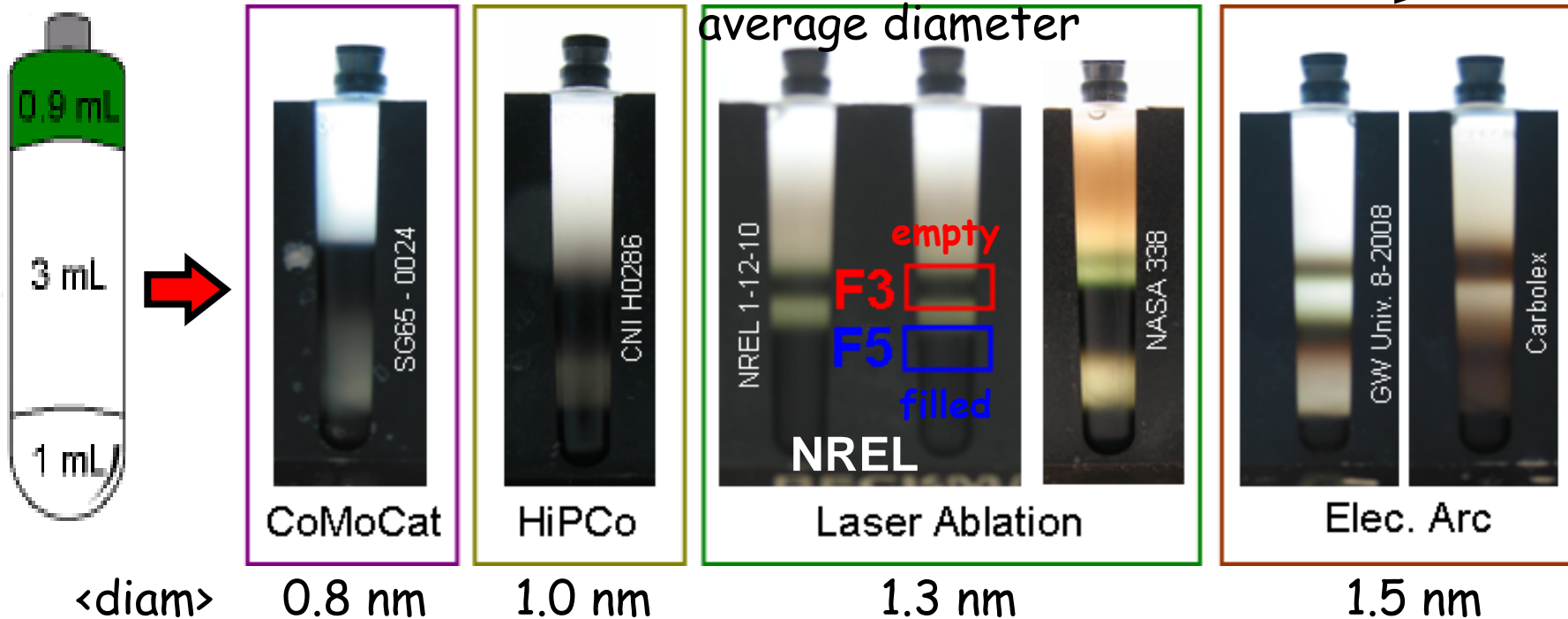
van Hove Singularities in density of states \rightarrow resonance Raman. Resonance energy with Raman peak position gives unique (n,m)

Resonance Excitation



$$I_S \propto \sum_{j,k} \left| \frac{\langle 0 | V_{opt} | j \rangle \langle j, N \pm 1 | V_{ex-ph} | k, N \rangle \langle k | V_{opt} | 0 \rangle}{(E_k - E_{ii} + i\Gamma)(E_j - E_q - E_{ii} + i\Gamma)} \right|^2$$

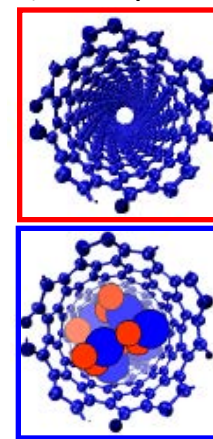
Separation for various diameters / synthesis



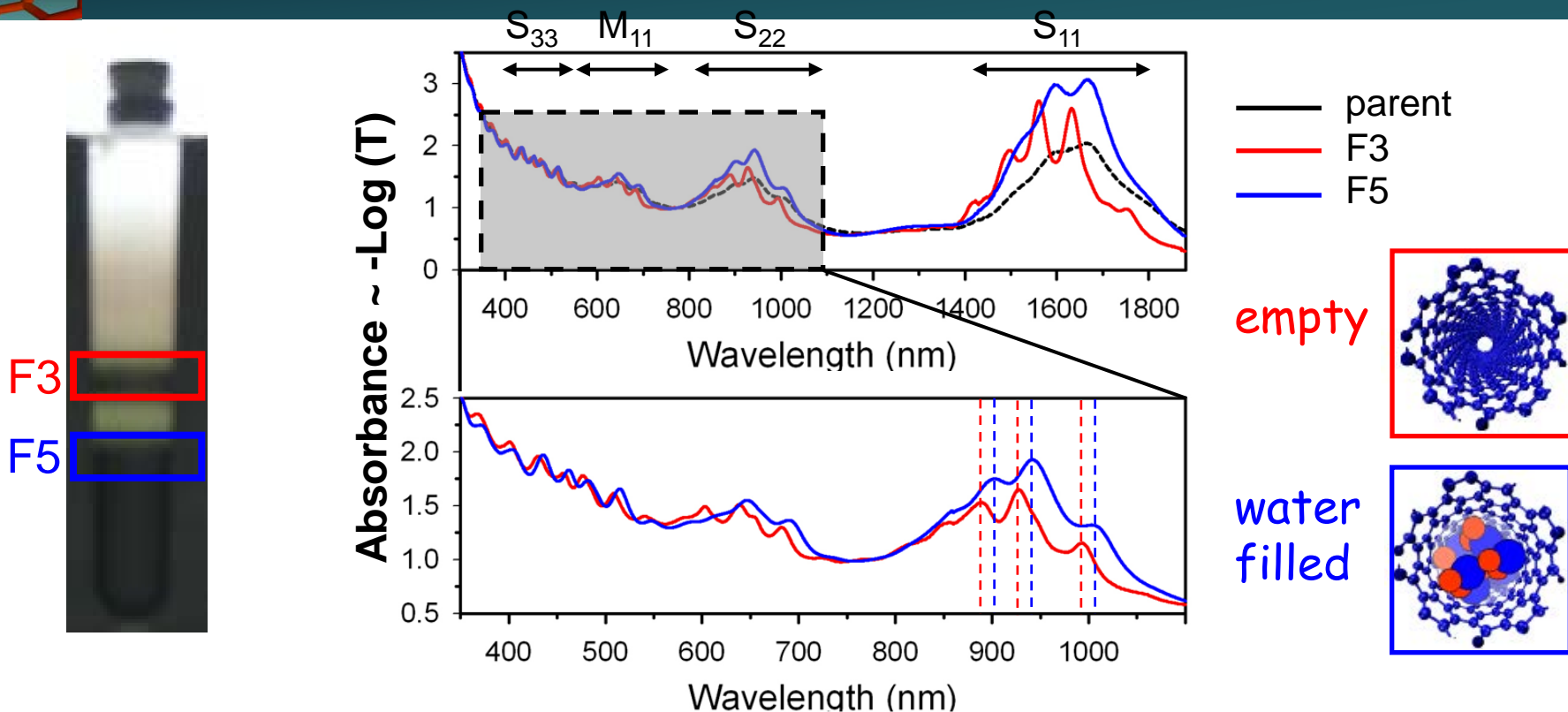
1. Separation into 2 distinct bands, increase with diameter
2. Lower band progresses further down with diameter
3. Motion of nanotube bands through medium is progressive

- robust results across various synthesis methods
- consistent with endohedral water-filling

*CoMoCat excluded



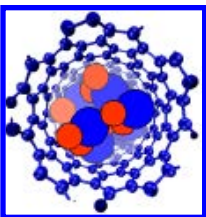
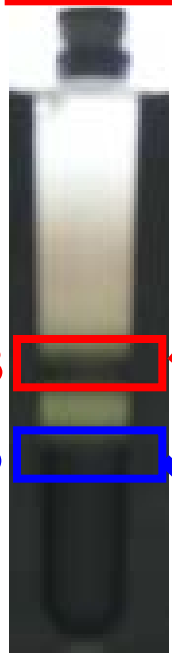
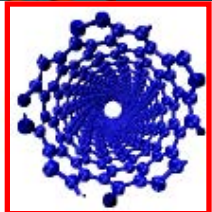
Optical Absorption: UV-Vis-NIR



- Peaks redshifted & broadened in F5 for all excitonic bands, including metallic
- Similar diameter distribution in two bands
- Spectral weight of F5 comparable to or larger than F3

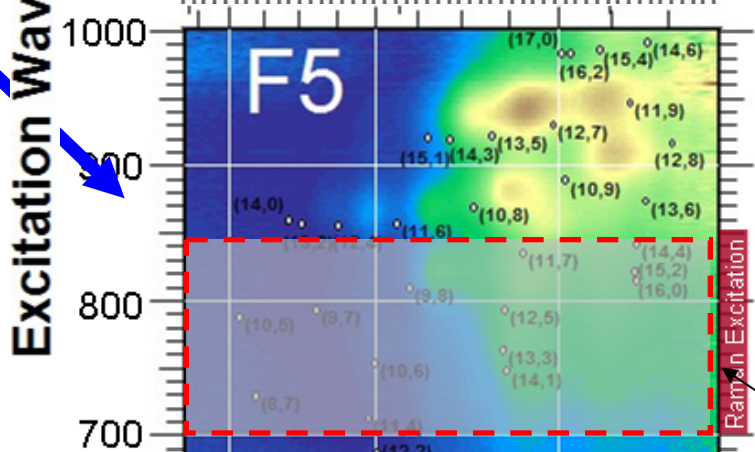
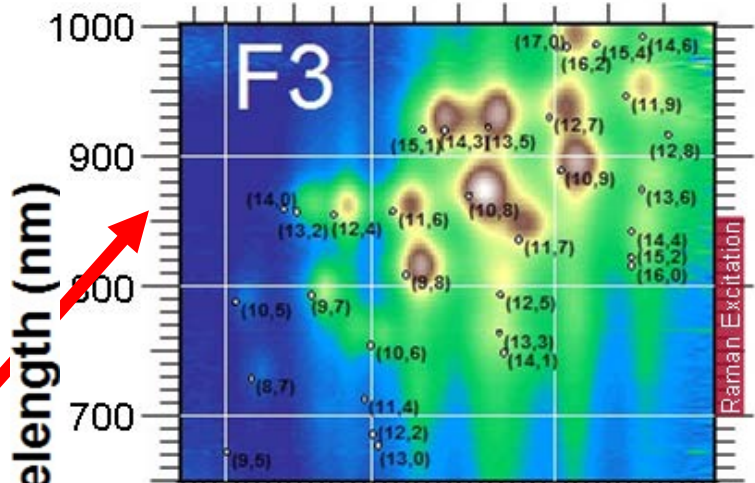
F5 not an aggregated state of F3 → filled

Near-IR Fluorescence



Emission Energy (eV)

1.0 0.9 0.8

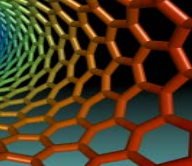


- Excitation & emission of F5 redshifted
- F3 brighter fluorescent intensity
- Parent materials matches F5 → typical dispersion water filled

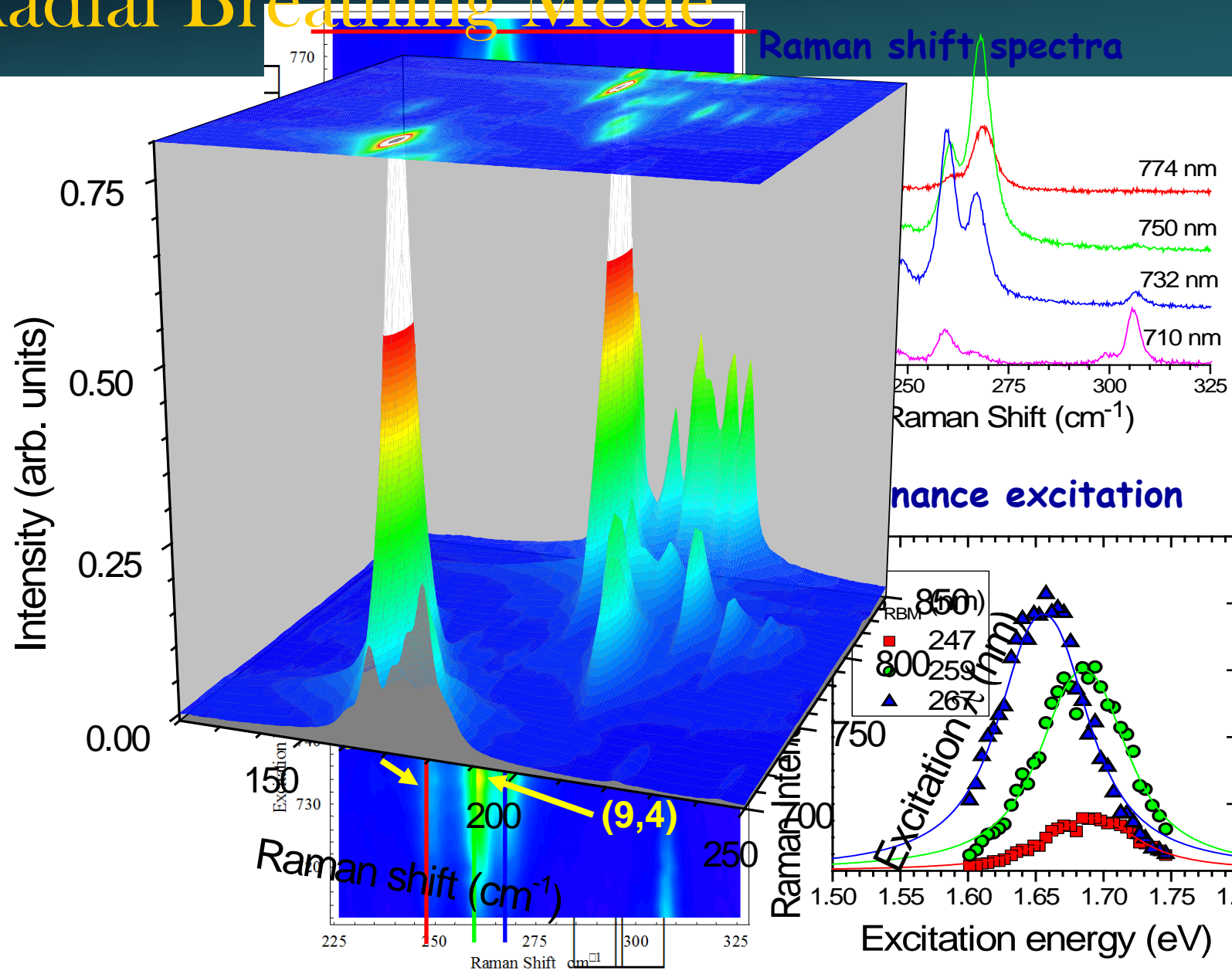
Resonance Raman

Intensity (arb. units) 0 1 2 3

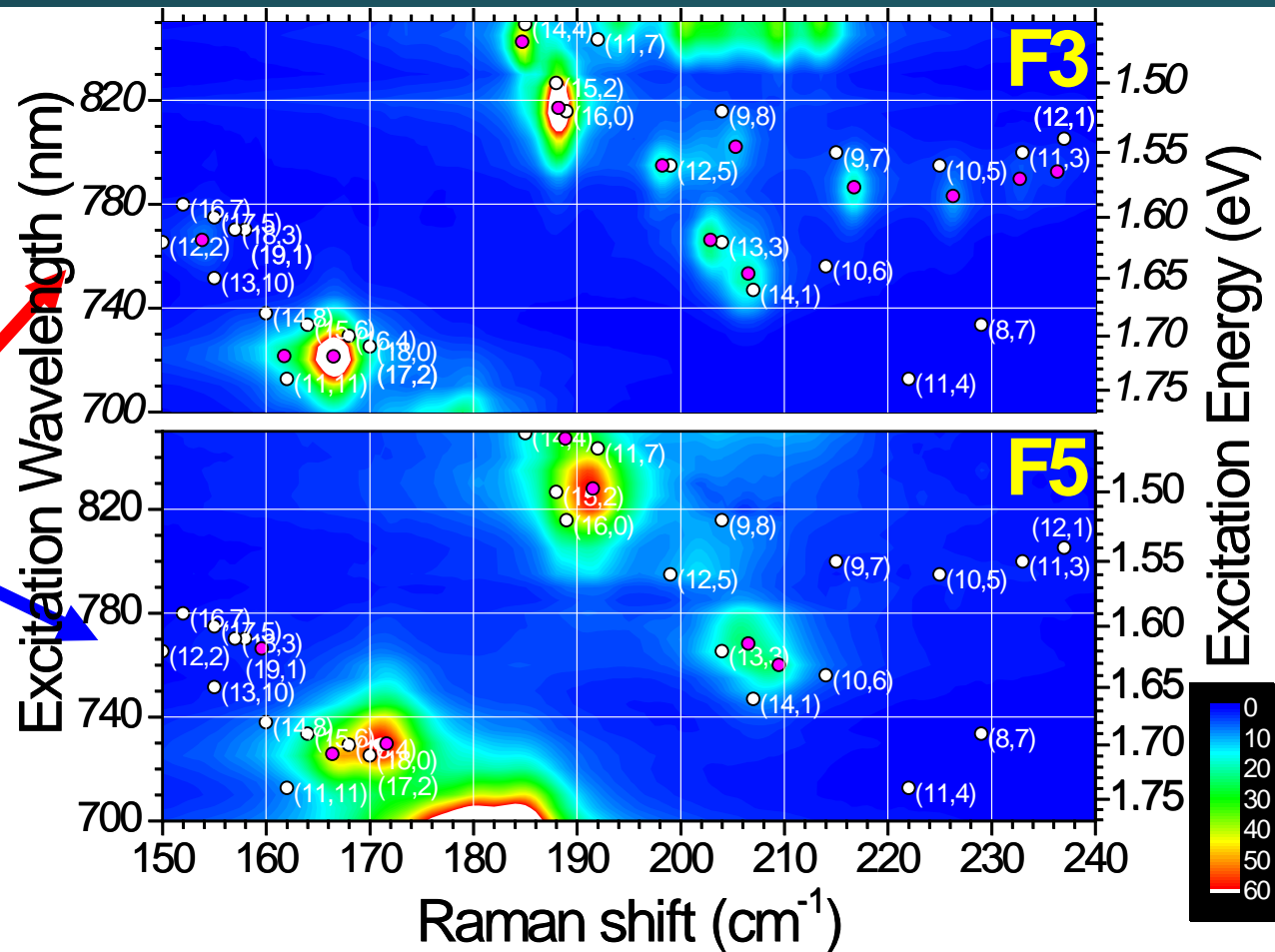
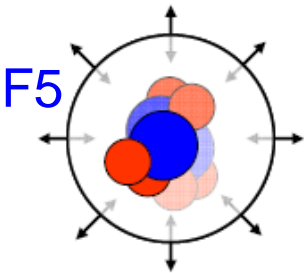
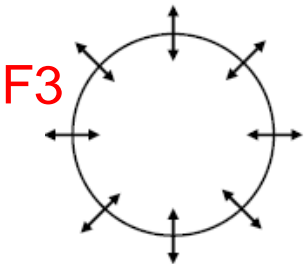
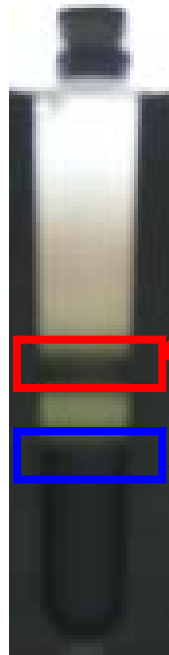
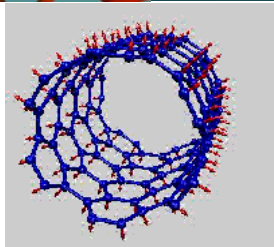
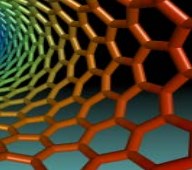
Emission Wavelength (nm)



Radial Breathing Mode

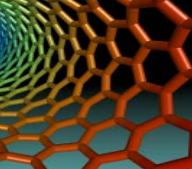


Radial Breathing Modes (RBMs)



- Both semiconducting (S22) & metallic (M11) SWCNTs in resonance
- Excitation energies redshift in F5 (filled)
- RBM phonon frequencies harden (higher energy) with filling

Excitation Profiles of RBMs



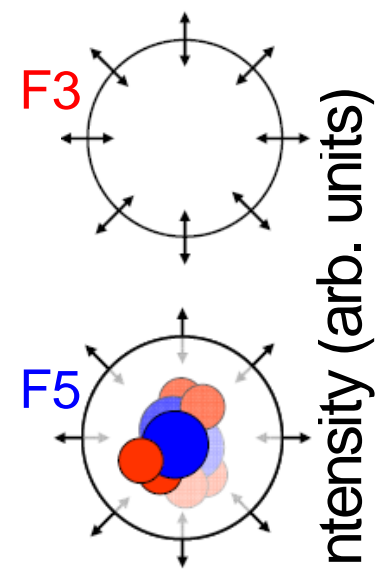
Excitation Wavelength (nm)

720

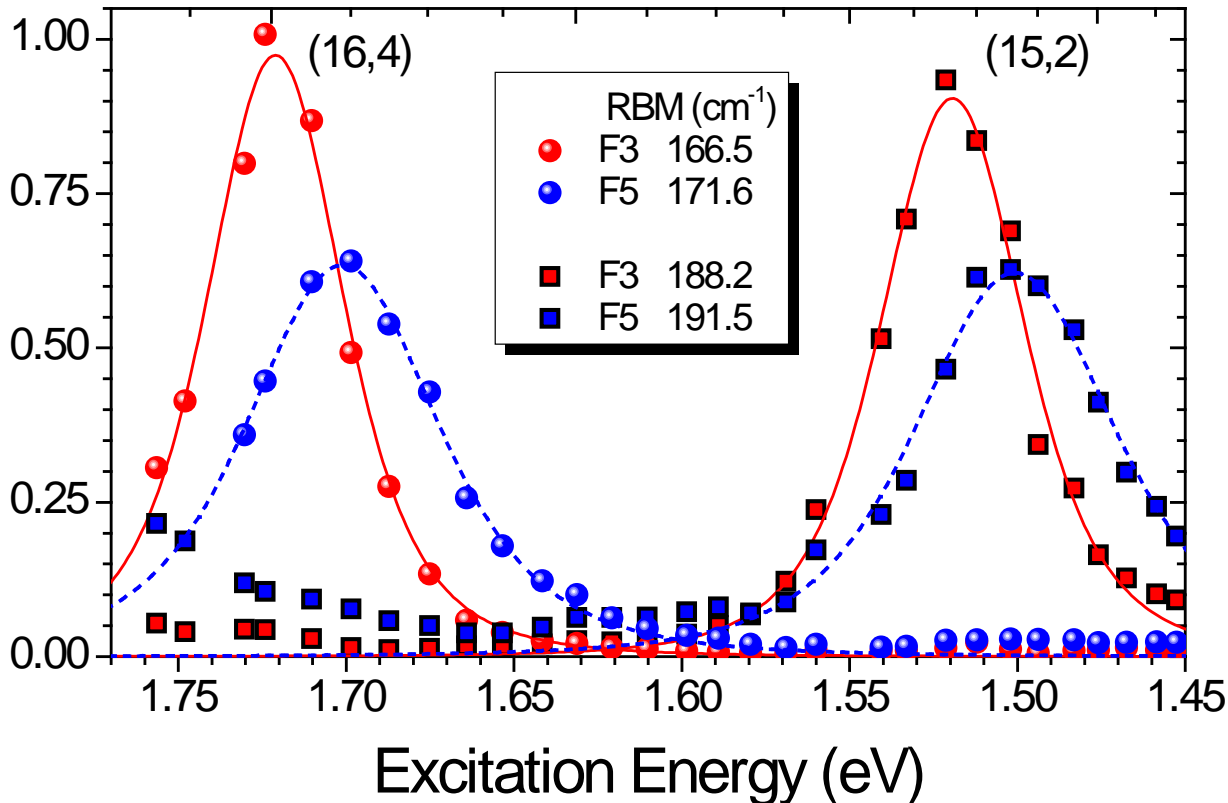
760

800

840



Intensity (arb. units)

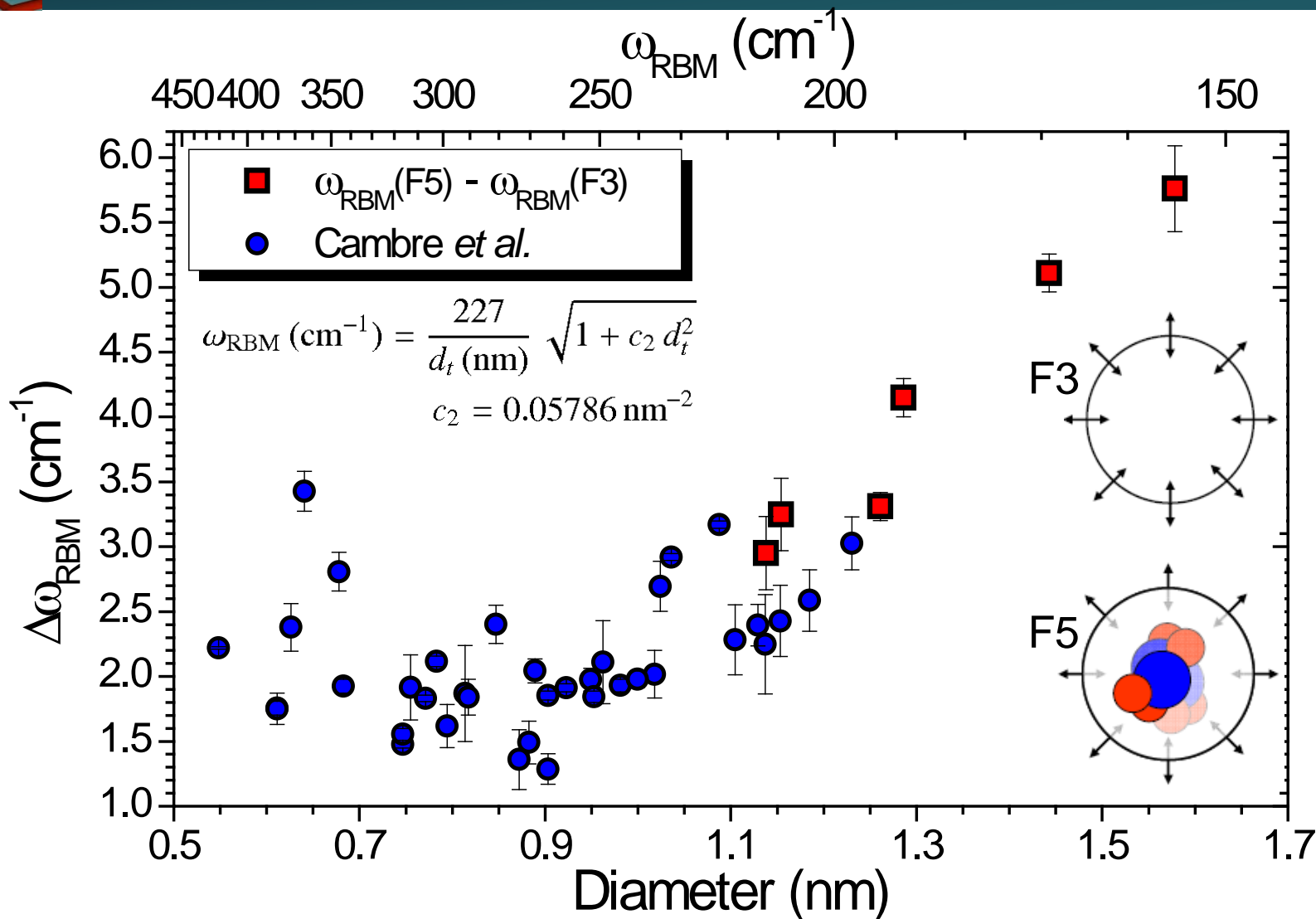


Excitation Energy (eV)

$$I_s \propto \sum_{j,k} \left| \frac{\langle 0|V_{opt}|j\rangle \langle j, N \pm 1|V_{ex-ph}|k, N\rangle \langle k|V_{opt}|0\rangle}{(E_k - E_{ii} + i\Gamma)(E_j - E_q - E_{ii} + i\Gamma)} \right|^2$$

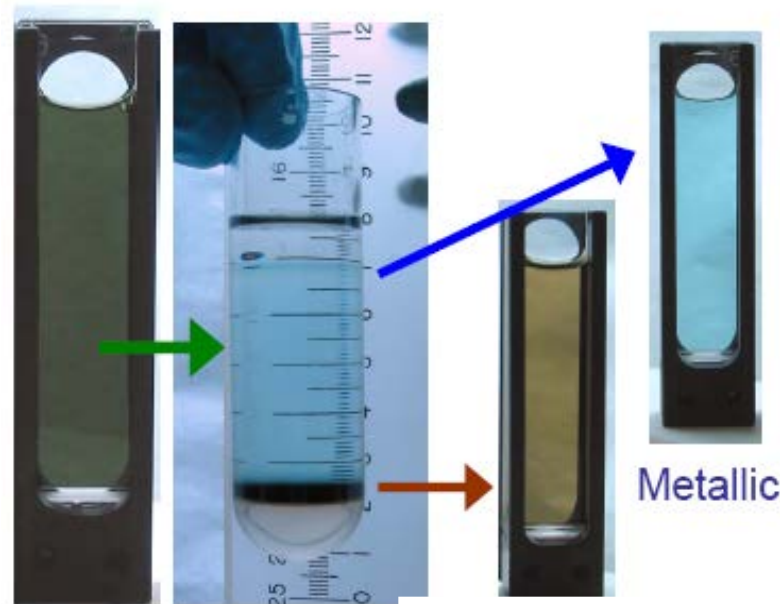
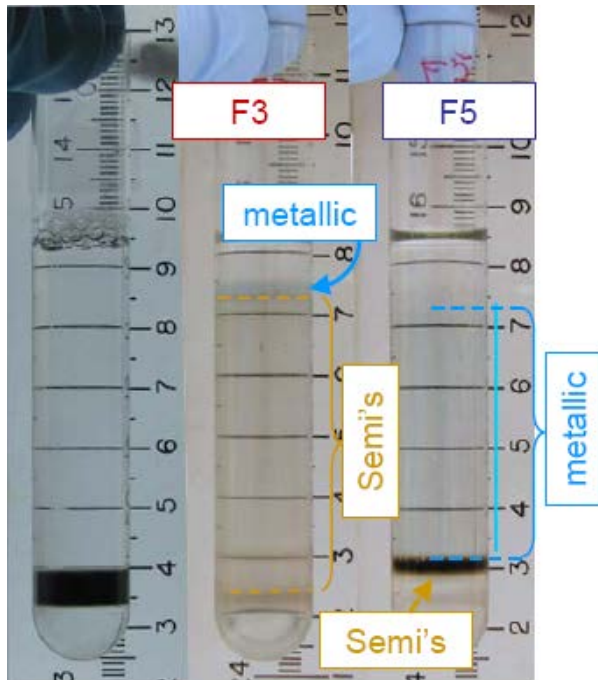
Excitations for F5 (filled) are red-shifted and broadened

Raman RBM Shift

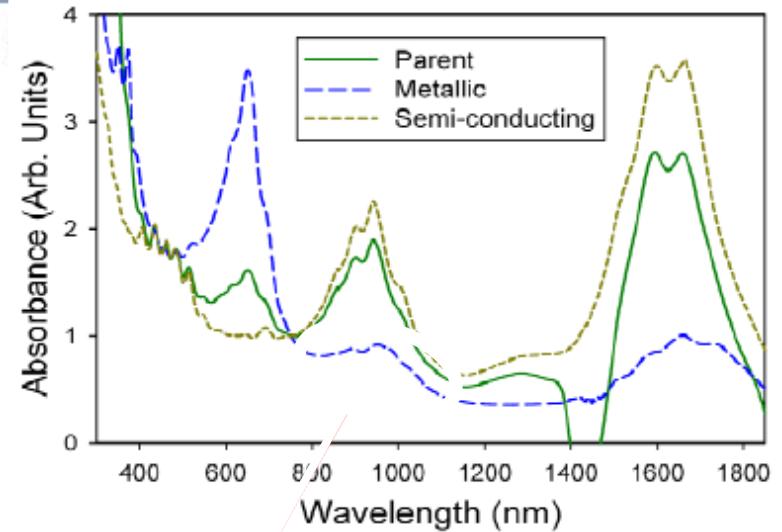


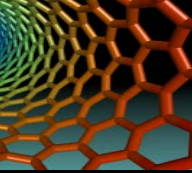
monotonic increase of hardening with increasing diameter

Separation by Electronic Type



- Subsequent processing and separation by electronic type
- F5 (filled) easier to separate into semi-conducting & metallic





DNA Dispersions of Carbon Nanotubes

LETTERS

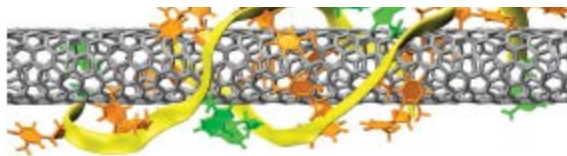
DNA sequence motifs for structure-specific recognition and separation of carbon nanotubes

Xiaomin Tu¹, Suresh Manohar², Anand Jagota^{2,3} & Ming Zheng¹

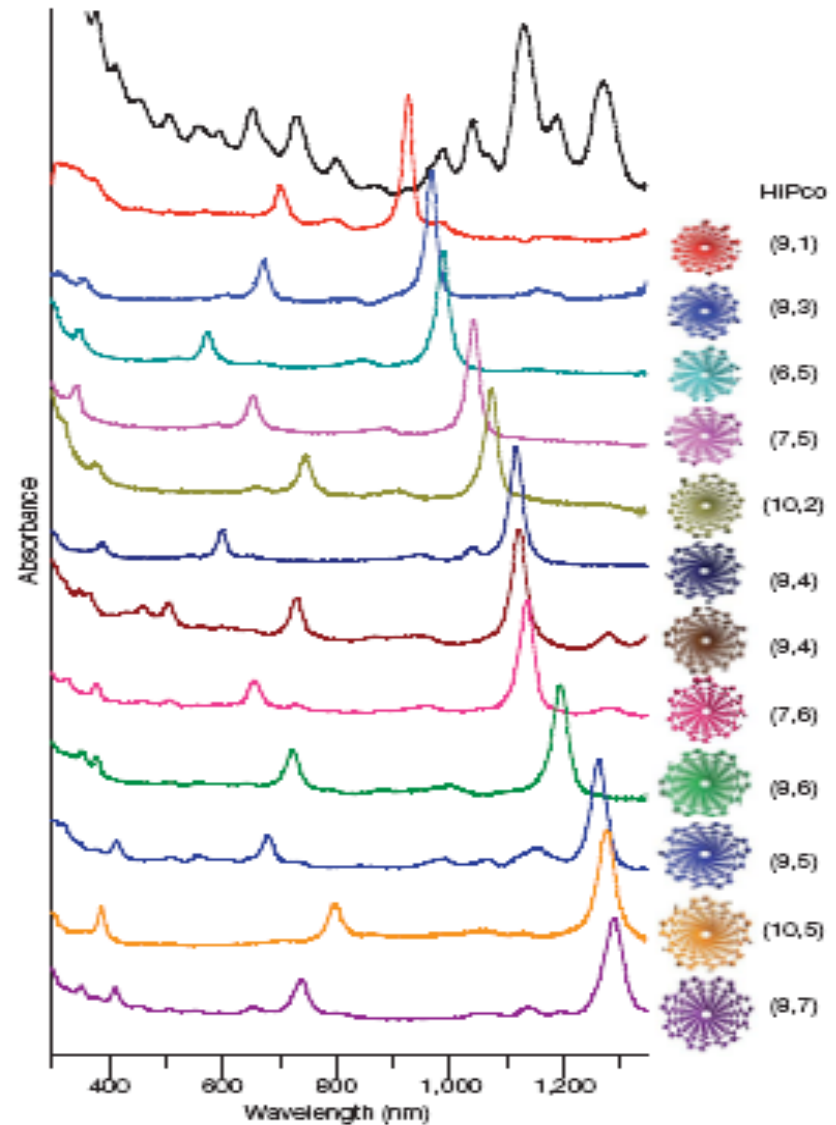
Table 1 | DNA sequence versus SWNT chirality

Chirality (n,m)	Sequences
(9,1)	(TCC) ₁₀ , (TGA) ₁₀ , (CCA) ₁₀
(8,3)	(TTA) ₄ TT, (TTA) ₃ TTGTT, (TTA) ₅ TT
(6,5)	(TAT) ₄ , (CGT) ₃ C
(7,5)	(ATT) ₄ , (ATT) ₄ AT
(10,2)	(TATT) ₂ TAT
(8,4)	(ATTT) ₃
(9,4)	(GTC) ₂ GT, (CCG) ₄
(7,6)	(GTT) ₃ G, (TGT) ₄ T
(8,6)	(GT) ₆ , (TATT) ₃ T, (TCG) ₁₀ , (GTC) ₃ , (TCG) ₂ TC, (TCG) ₄ TC, (GTC) ₂
(9,5)	(TGTT) ₂ TGT
(10,5)	(TTTA) ₃ T
(8,7)	(CCG) ₂ CC

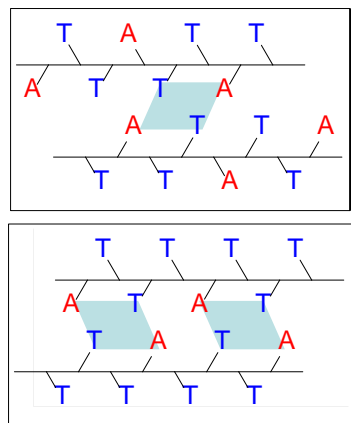
DNA sequences enabling chromatographic purification of single chirality semiconducting SWNTs.



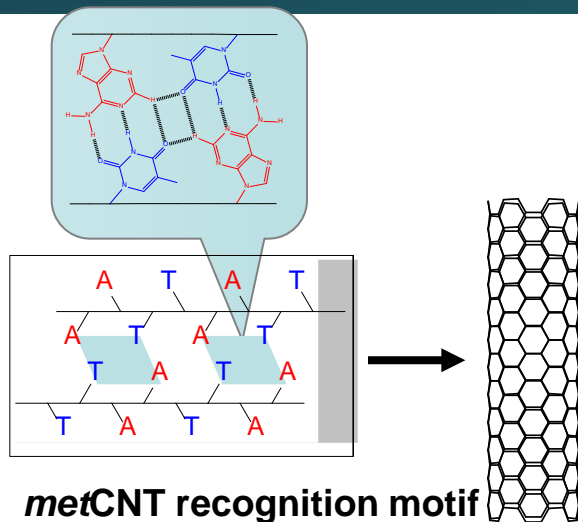
c



Sequence motif variation



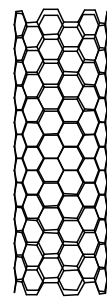
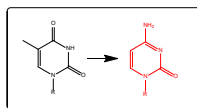
*semi*CNT recognition motifs



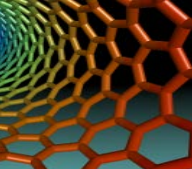
Enabled single
chirality armchair
nanotubes

TTATTATTATTATT for (8,3)
↓

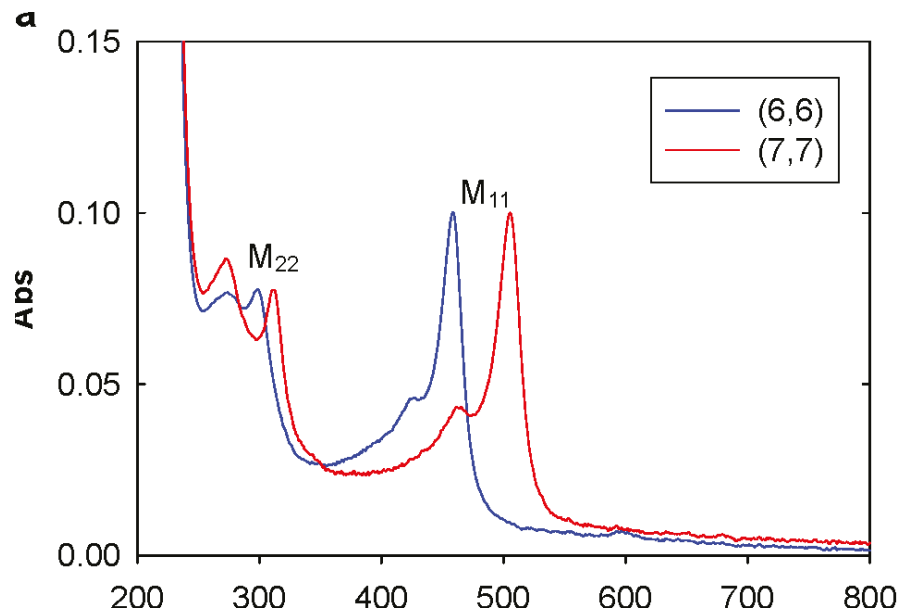
CTATTATTATTATT
T**C**ATTATTATTATT
TTA**C**TATTATTATT
TTAT**C**ATTATTATT
TTATTACTATTATT for (7,7)
TTATTAT**C**ATTATT
TTATTATT**A**CATT
TTATTATTAT**C**ATT
TTATTATTATT**A**C
TTATTATTATTAT**C**



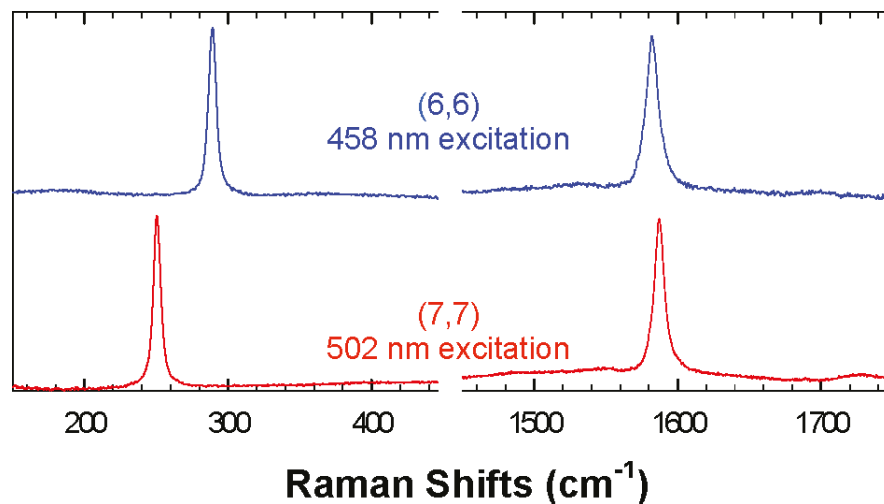
T to C scanning mutation
J. Am. Chem. Soc. 2011, 133, 129981



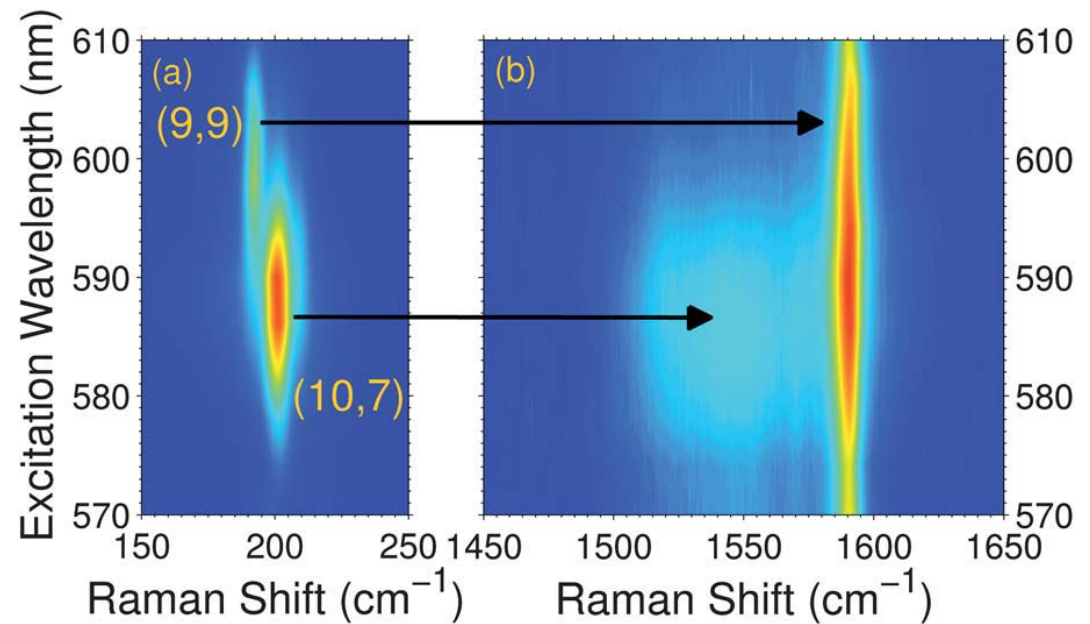
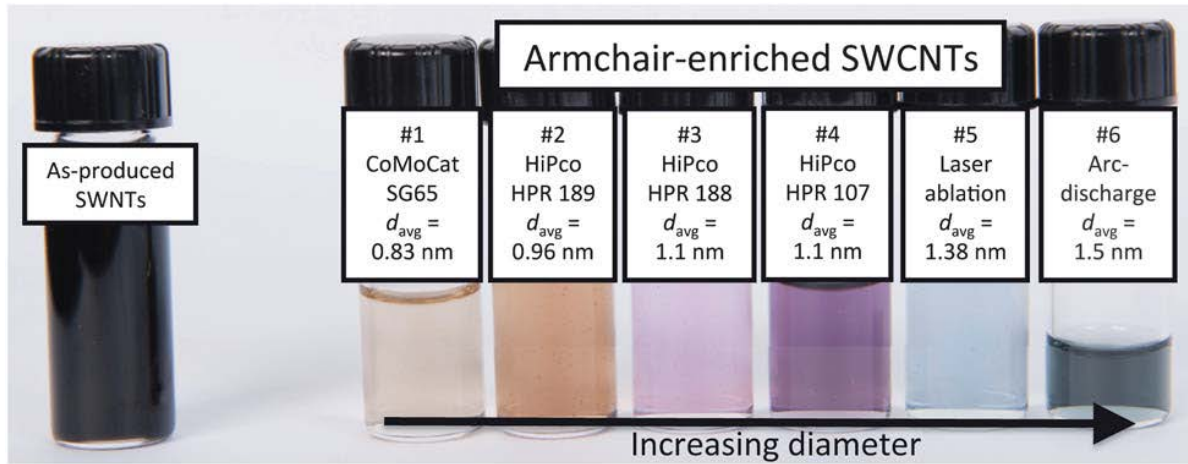
Optical Properties of Armchair Tubes

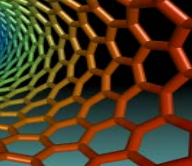


Single G band

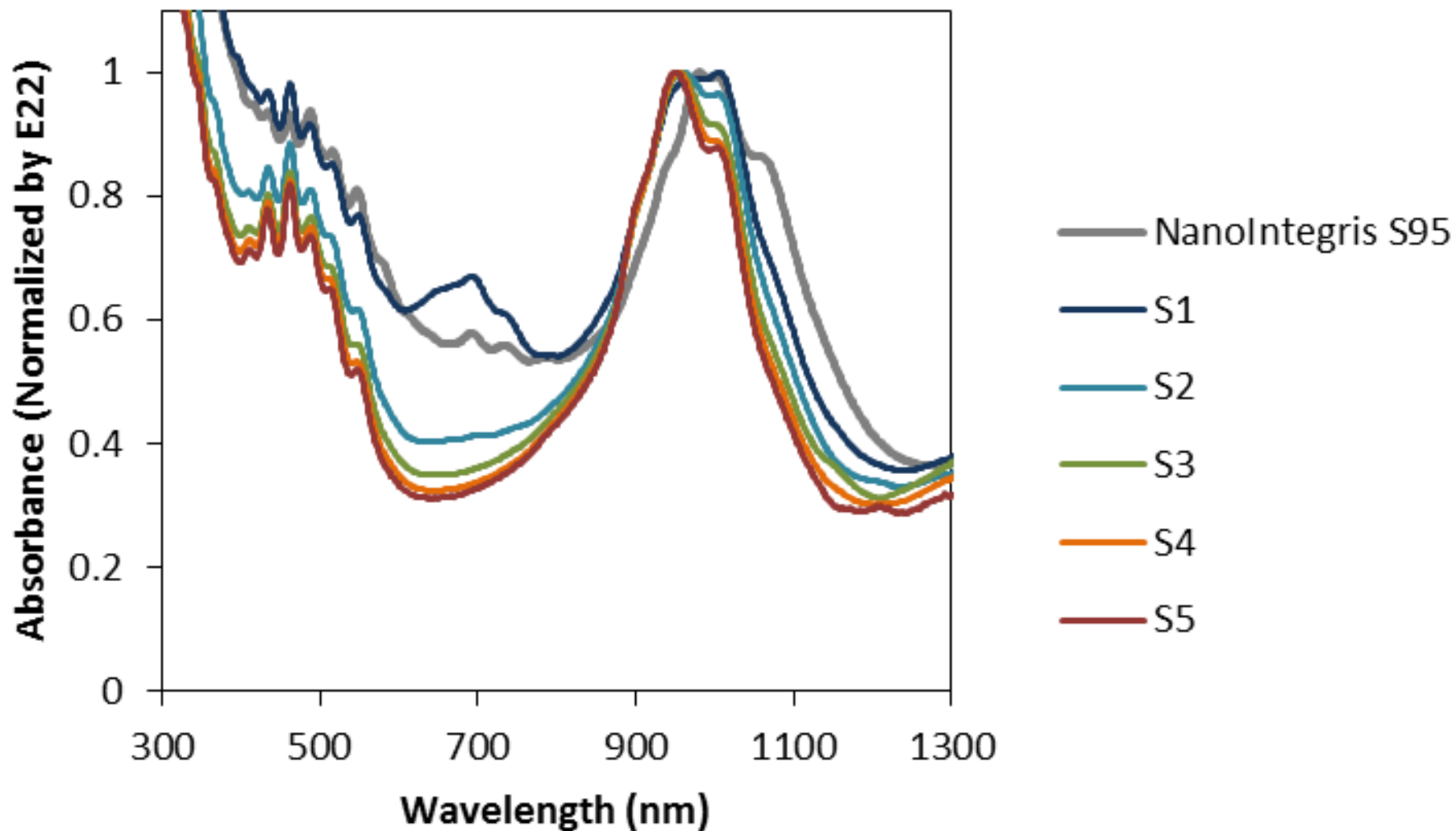


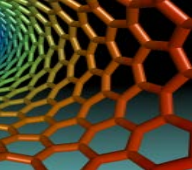
Armchair Separation by Other Techniques



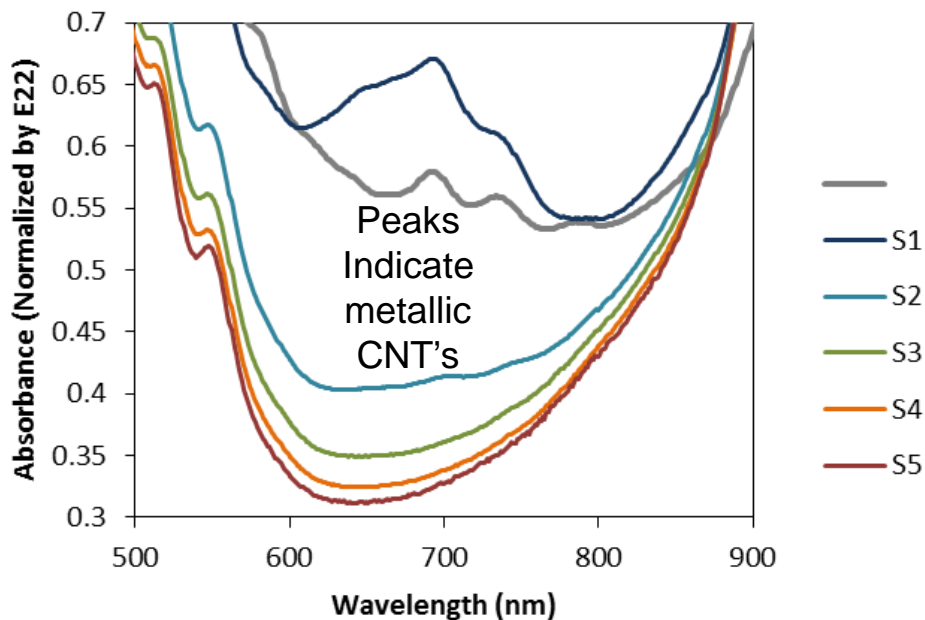


Purity metrology for SWCNTs





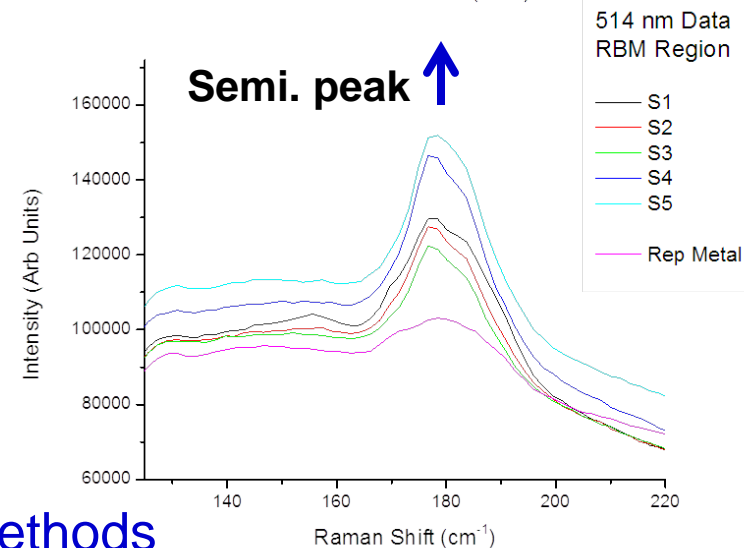
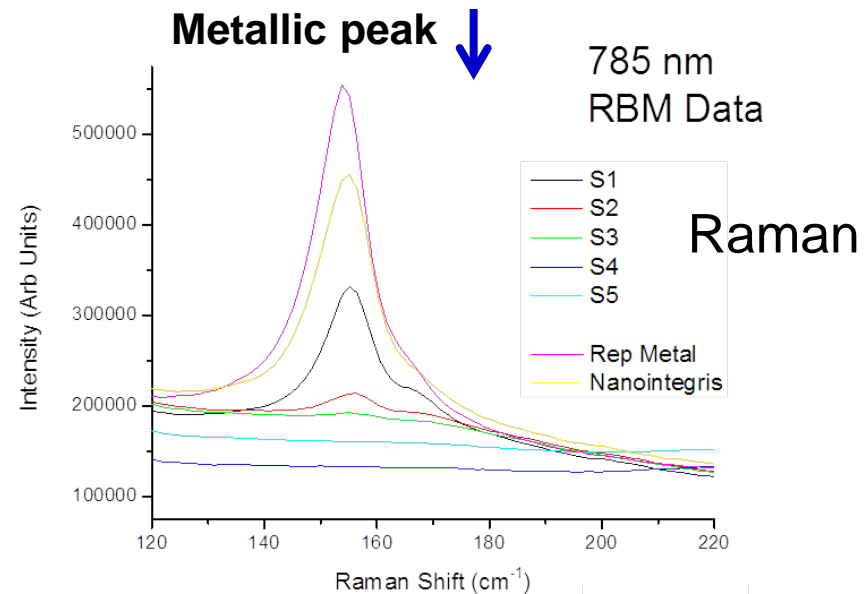
Purity metrology for SWCNTs



SWCNT's can now be purified to levels that test the resolution of purity metrology.

- Absorbance: quick
- Raman: more powerful, higher resolution
- Goal 99.9999%

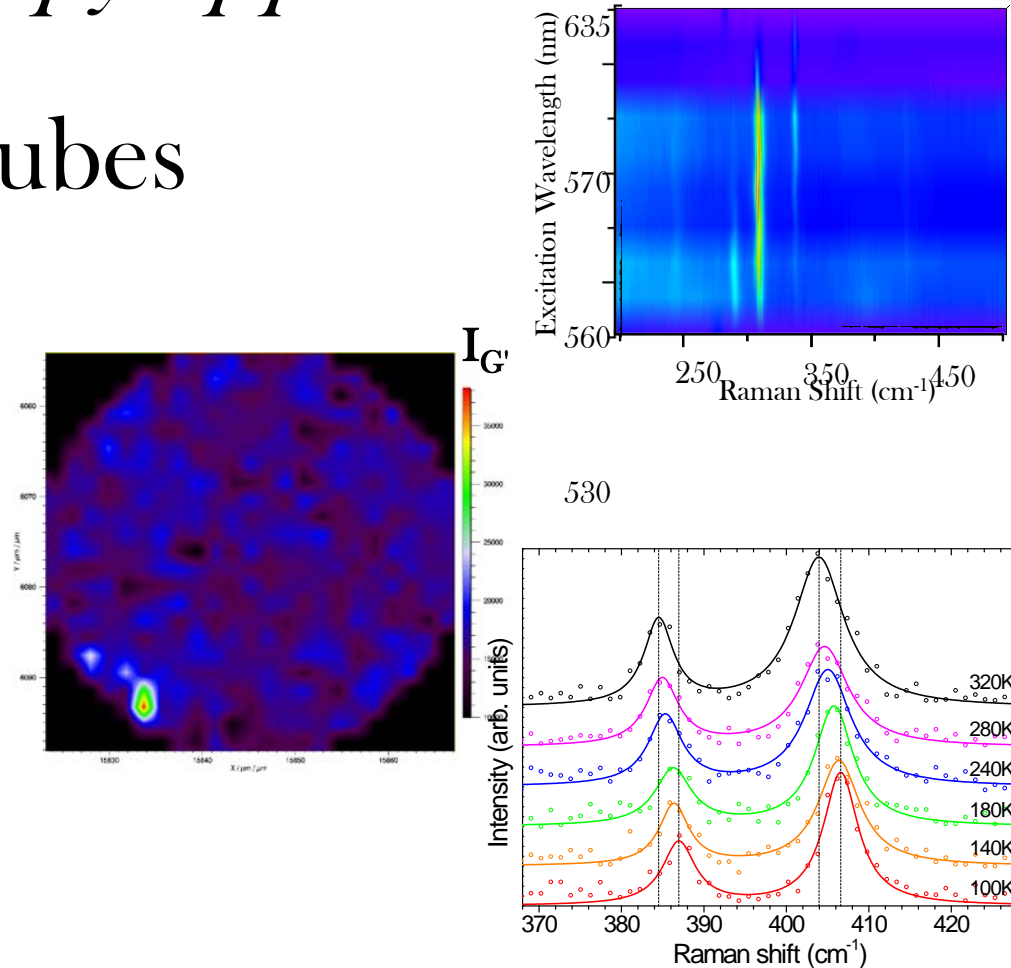
Actively improving accuracy of optical methods

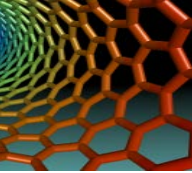


Outline

Raman spectroscopy applied to

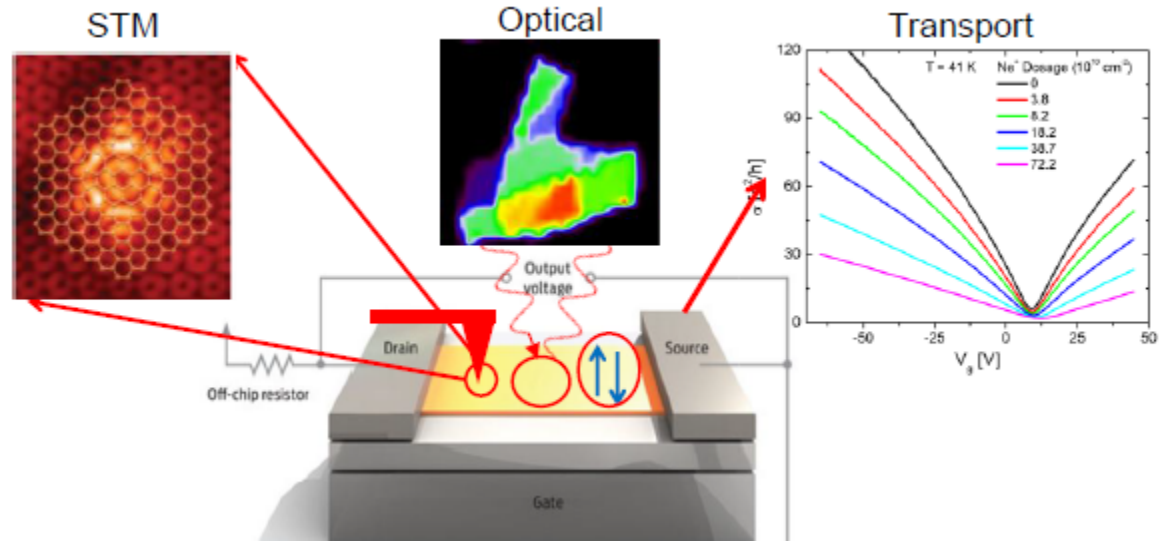
- Carbon Nanotubes
- 2D Materials
 - Graphene
 - MoS₂





NIST Graphene Team

Bridging Measurement Length Scales to Advance Graphene Device Technologies



Twisted Graphene

NANO LETTERS

Letter
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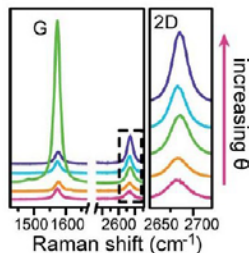
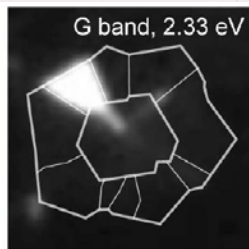
Angle-Resolved Raman Imaging of Interlayer Rotations and Interactions in Twisted Bilayer Graphene

Robin W. Havener,[†] Houlong Zhuang,[‡] Lola Brown,[§] Richard G. Hennig,[‡] and Jiwoong Park^{*,§,⊥}

[†]School of Applied and Engineering Physics, Cornell University, Ithaca, New York 14853, United States
[‡]Department of Materials Science and Engineering, Cornell University, Ithaca, New York 14853, United States
[§]Department of Chemistry and Chemical Biology, Cornell University, Ithaca, New York 14853, United States
[⊥]Kavli Institute at Cornell for Nanoscale Science, Cornell University, Ithaca, New York 14853, United States

Supporting Information

ABSTRACT: Few-layer graphene is a prototypical layered material, whose properties are determined by the relative orientations and interactions between layers. Exciting electrical and optical phenomena have been observed for the special case of Bernal-stacked few-layer graphene, but structure–property correlations in graphene which deviates from this structure are not well understood. Here, we combine two direct imaging techniques, dark-field transmission electron microscopy (DF-TEM) and widefield Raman imaging, to



Enhanced G

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Letter
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Observation of Layer-Breathing Mode Vibrations in Few-Layer Graphene through Combination Raman Scattering

Chun Hung Lui,[†] Leandro M. Malard,[†] SukHyun Kim,[†] Gabriel Lantz,[†] François E. Laverge,[†] Rūichiro Saito,[‡] and Tony F. Heinz^{*,†}

[†]Departments of Physics and Electrical Engineering, Columbia University, 538 West 120th Street, New York, New York 10027, United States

Nano Research

DOI 10.1007/s12274-013-0304-z

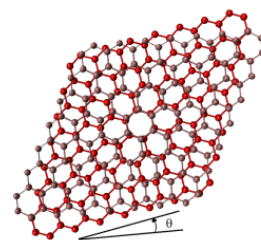
ISSN 1998-0124

CN 11-5974/O4

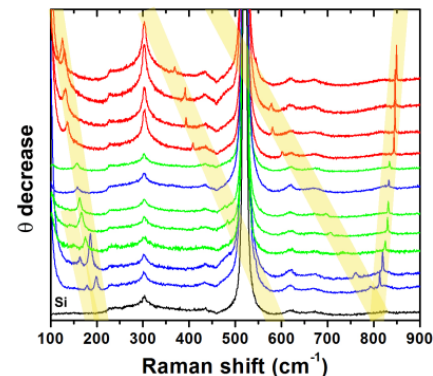
Research Article

Raman-scattering study of the phonon dispersion in twisted bi-layer graphene

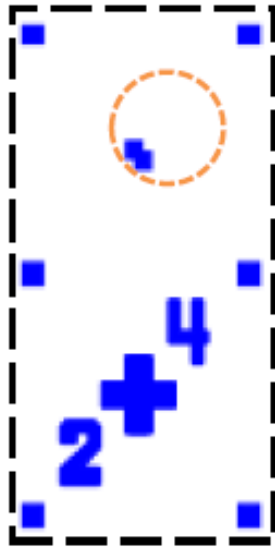
Jessica Campos-Delgado¹ (✉), Luiz G. Cançado², Carlos A. Achete³, Ado Jorio², Jean-Pierre Raskin¹



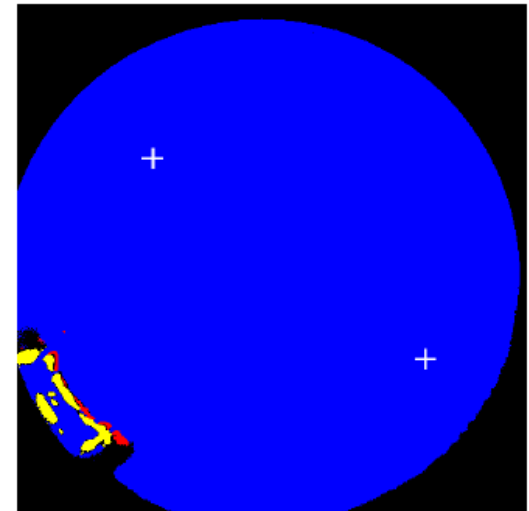
New Raman Modes



Correlating LEEM with Raman

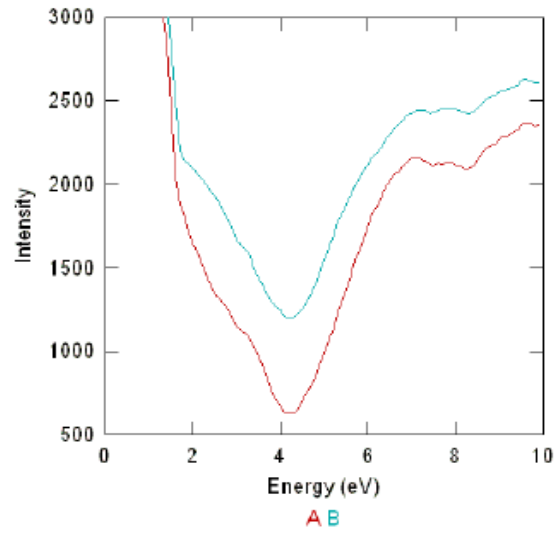
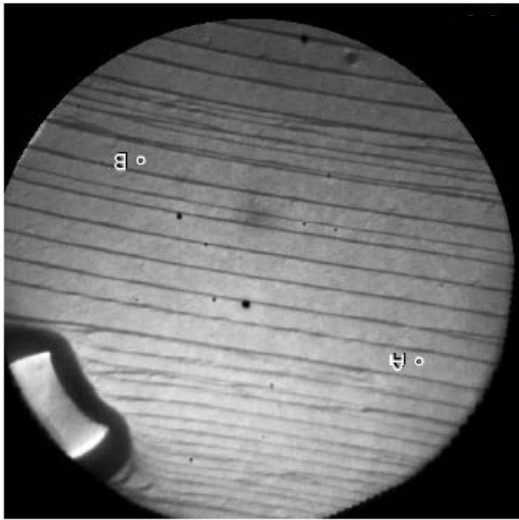


Thickness Map
Uniformly Single Layer

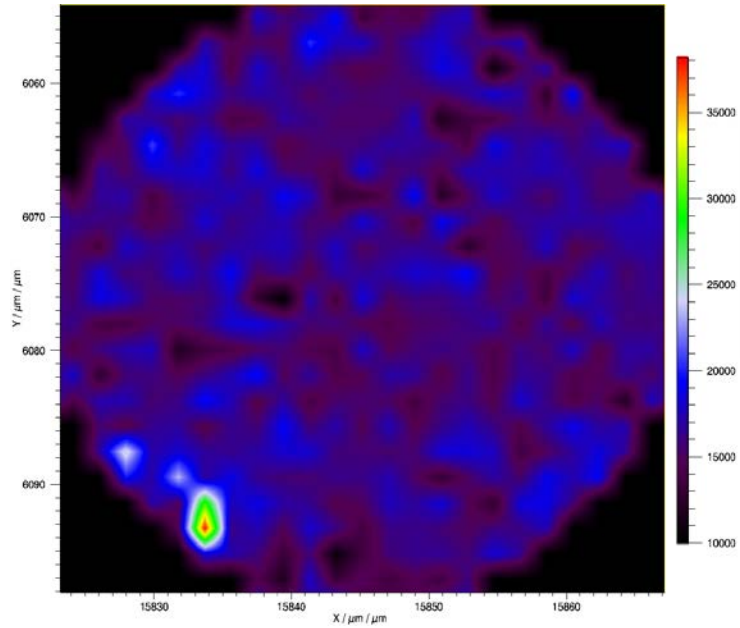
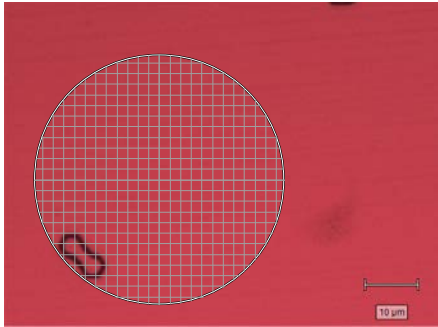


Reflectivity Image
@ 5.7 eV

Two respective curves

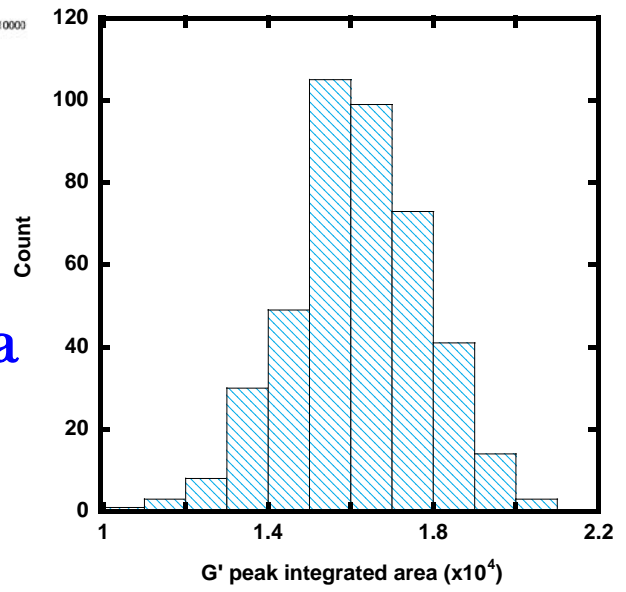
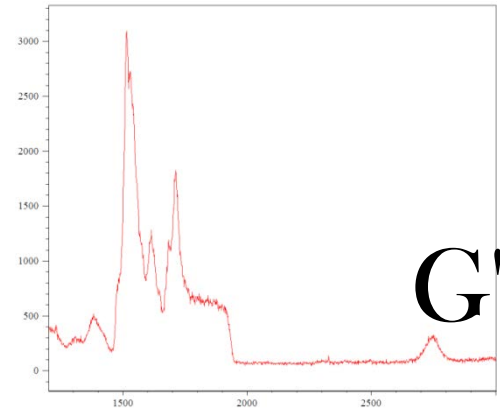


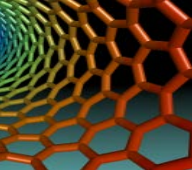
Correlating LEEM with Raman



**G' peak
Integrated area
map**

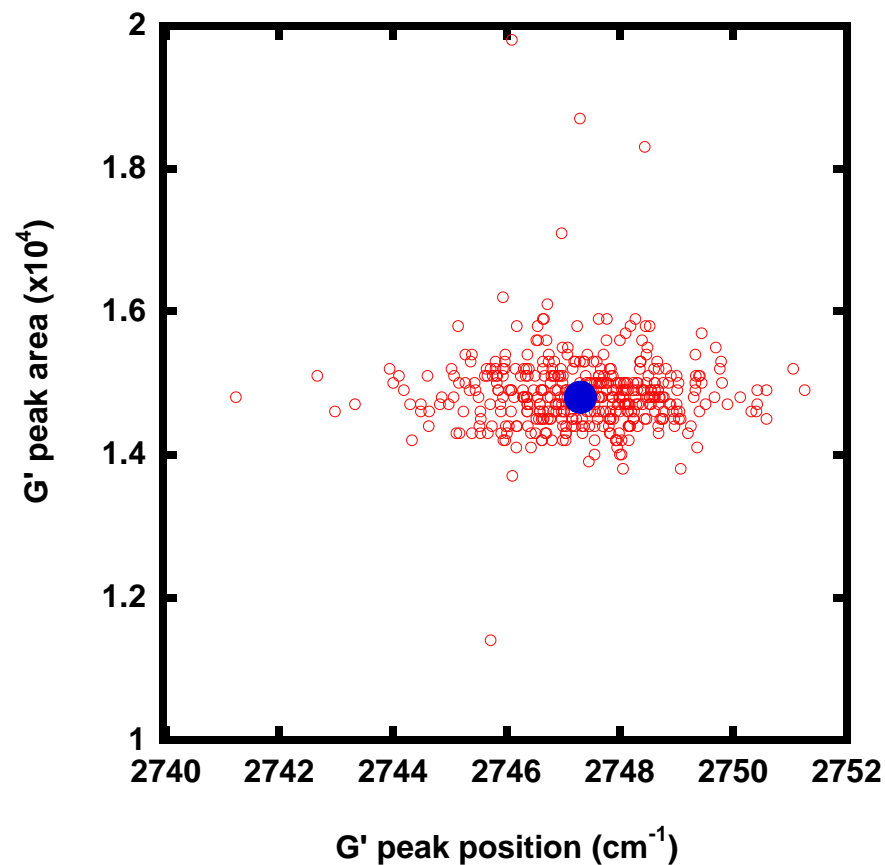
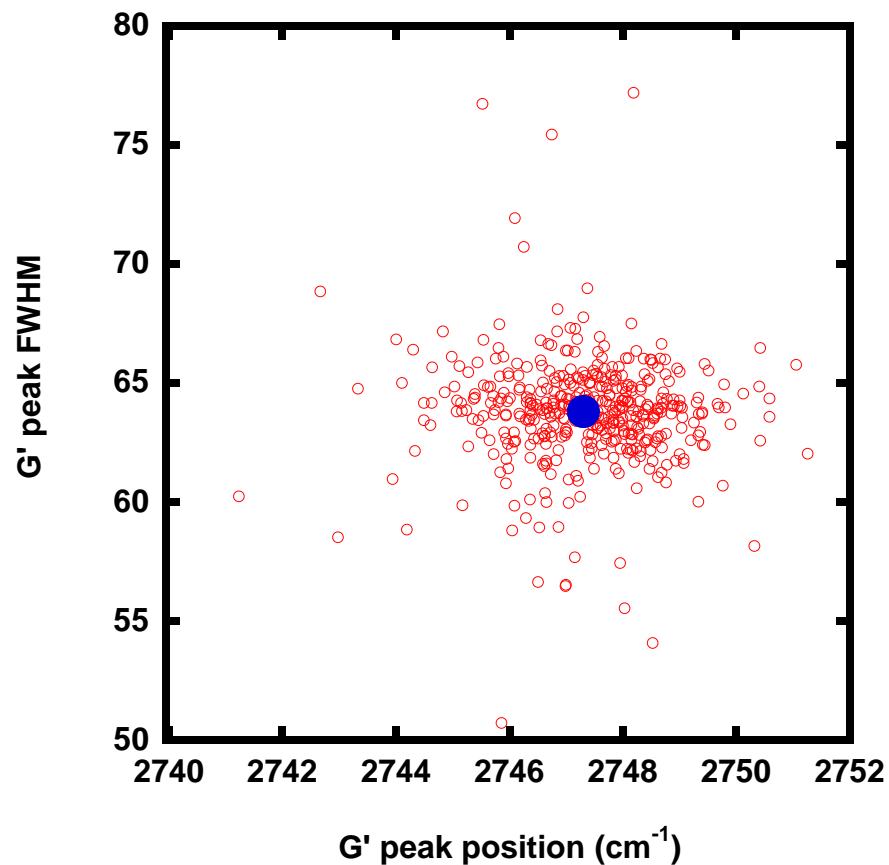
2 micron steps
**Average
Integrated Area**
 1.61 ± 0.19



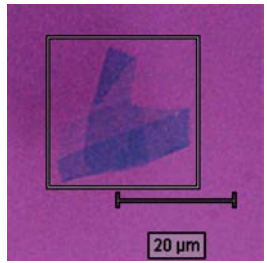


Variation in Raman Data for Single Layer

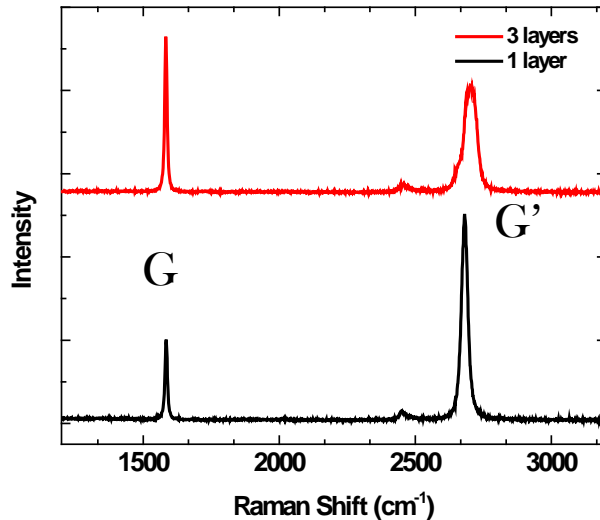
Blue dots are average value



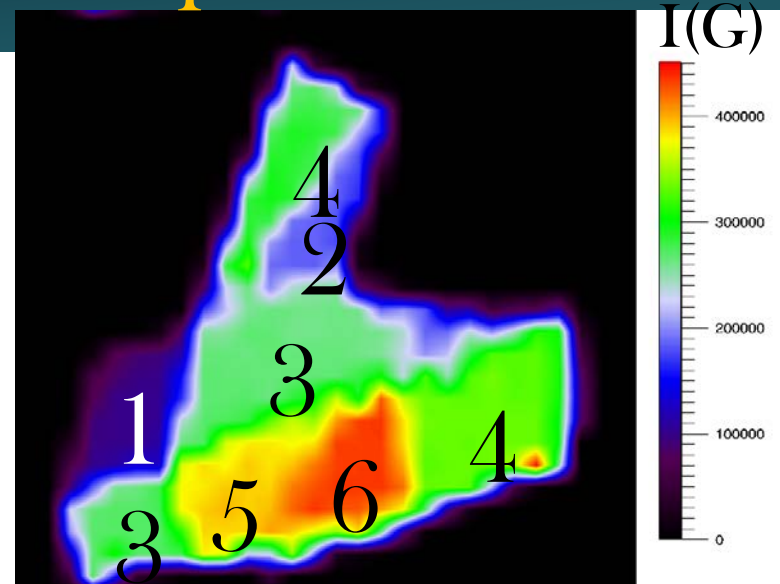
Raman Mapping on Graphene



Optical image



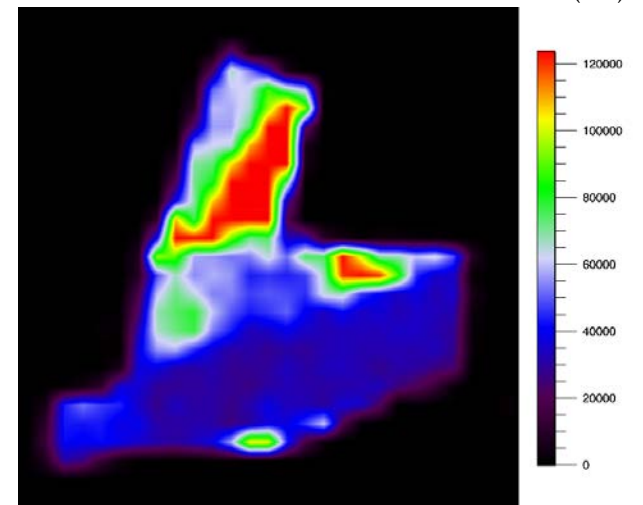
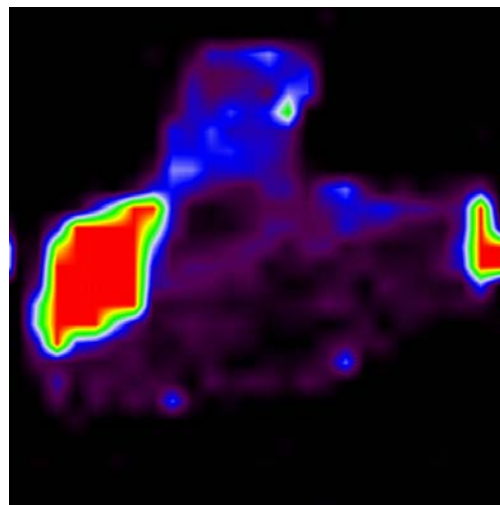
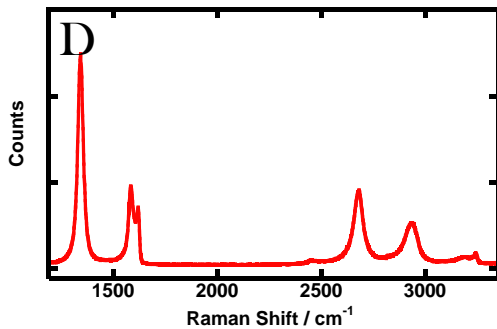
Raman Spectra



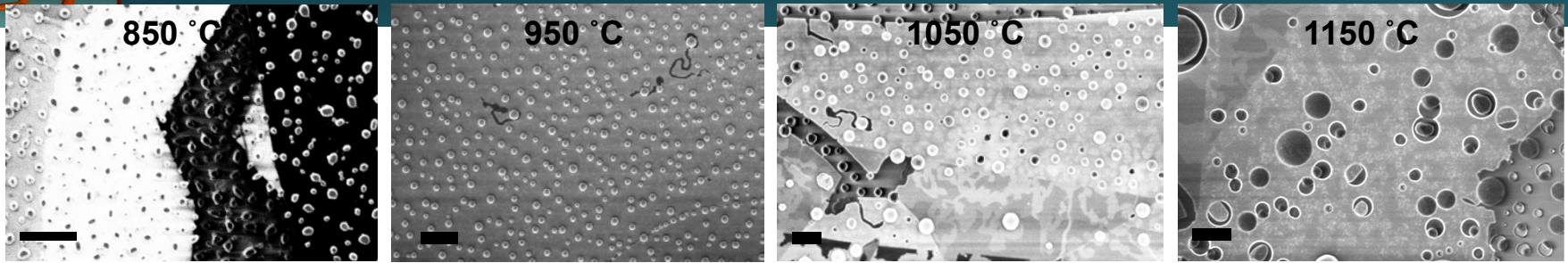
Raman mapping

Tracking chemical transformation of graphene

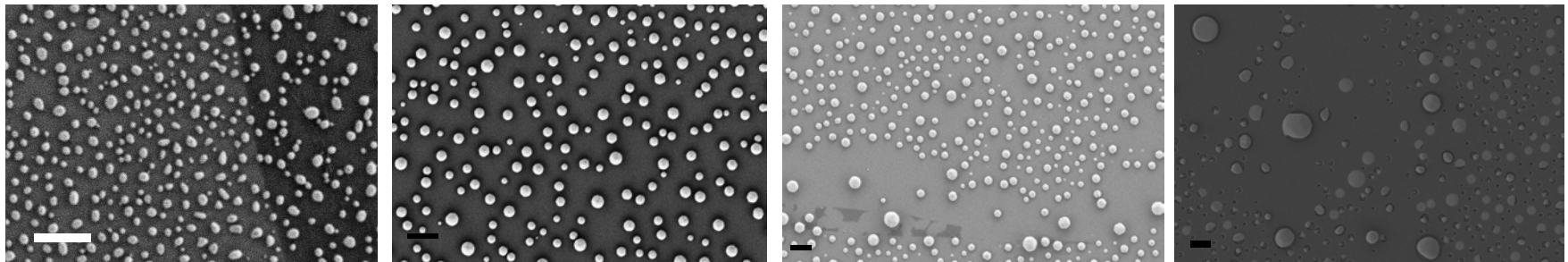
D peak shows up due to chemical reaction on graphene



Etching Graphene by Metallic Nanoparticles



InLens detector

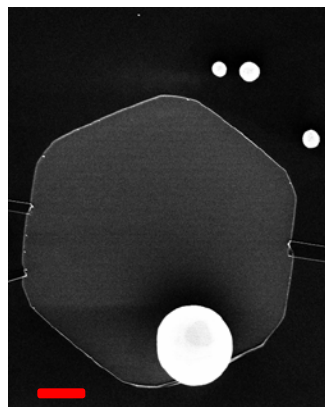


SE2 detector

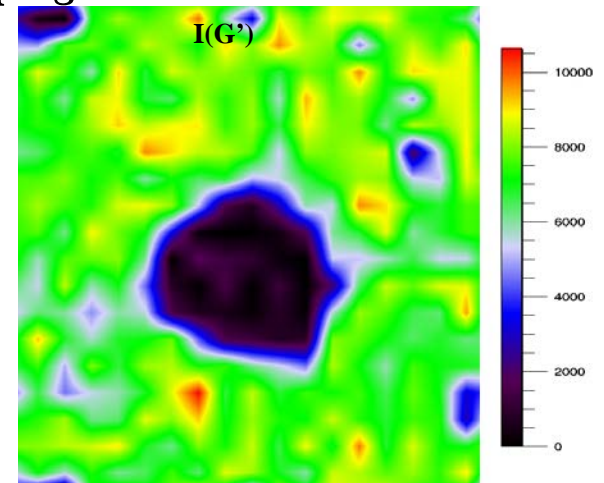
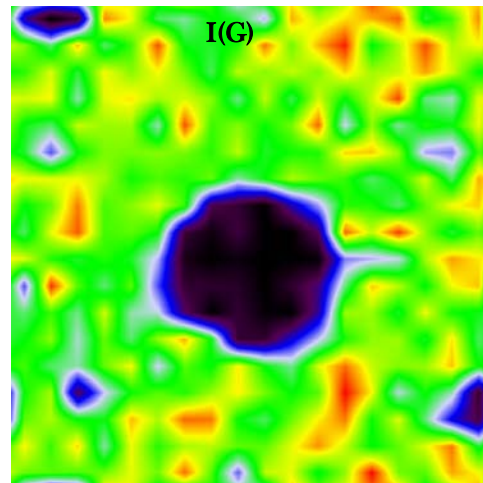
scale bar: 1 μm

SEM

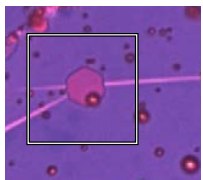
Raman Mapping

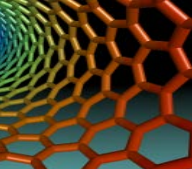


Scale bar: 1 μm



Hexagon
Pits
Zigzag Edge





Cutting Graphene with Cu Nanoparticles

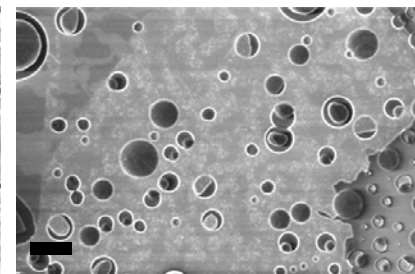
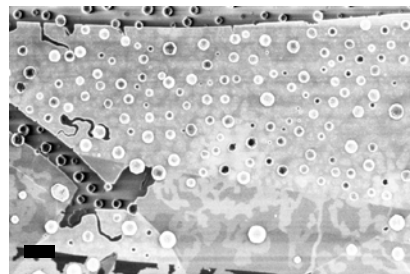
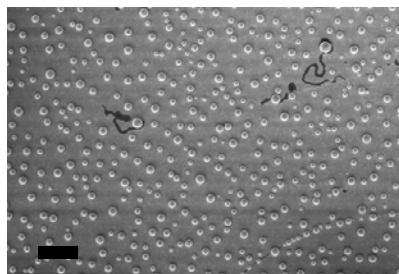
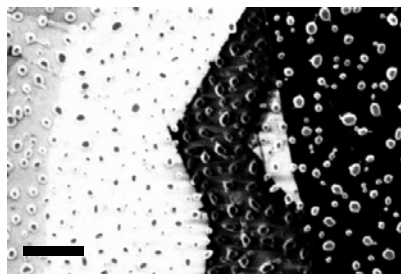
Summary of Cu Annealing

850 °C

950 °C

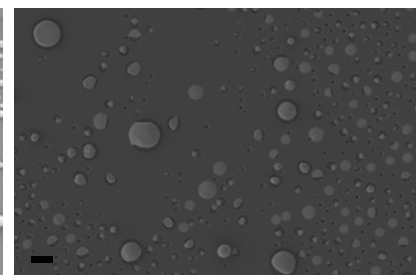
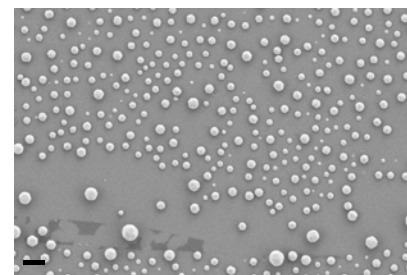
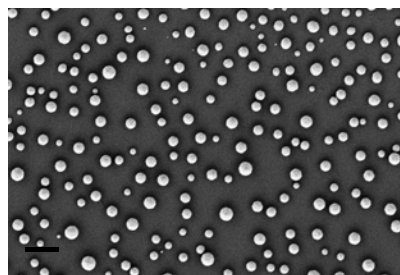
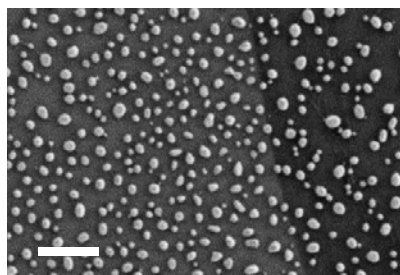
1050 °C

1150 °C



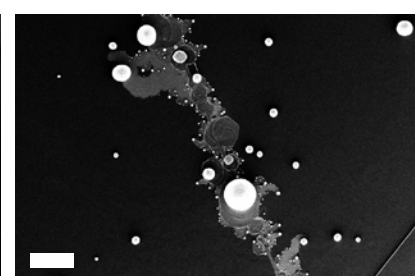
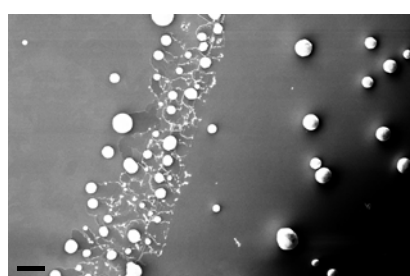
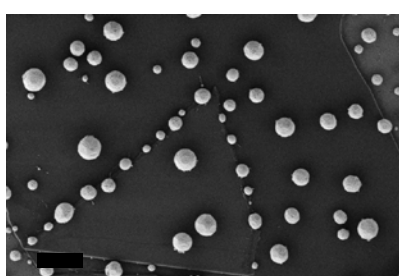
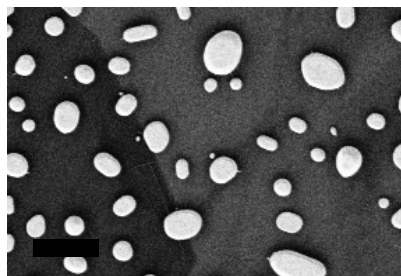
monolayer

InLens



monolayer

SE2

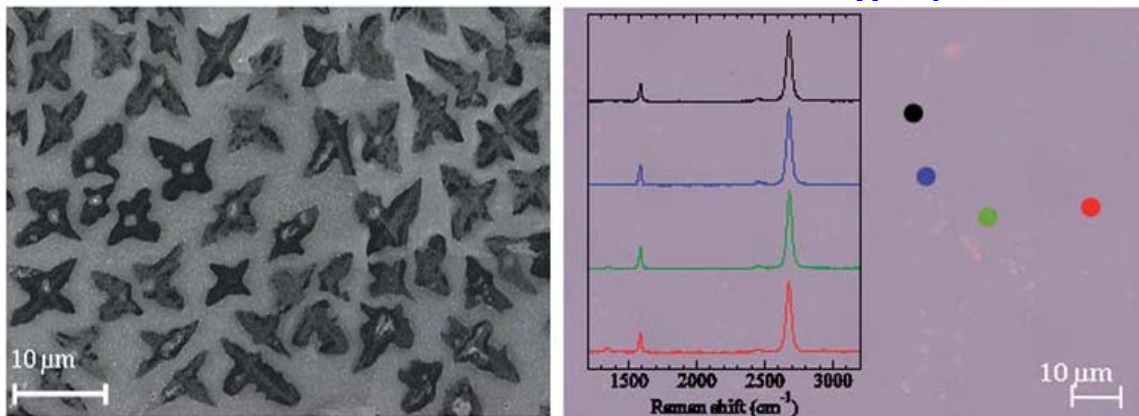


graphite

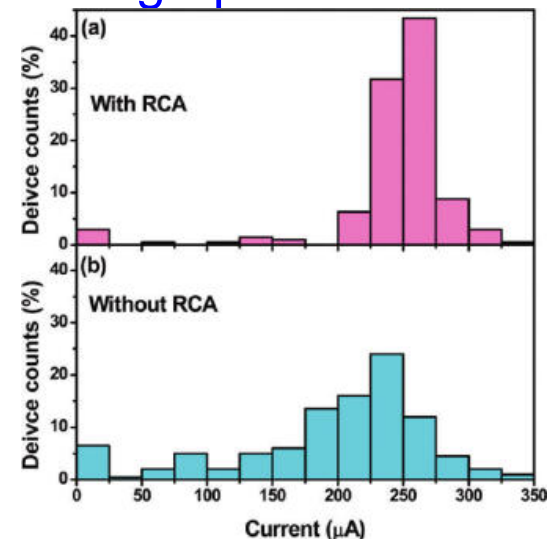
scale bar: 1 μm

Raman Spectroscopy of Graphene

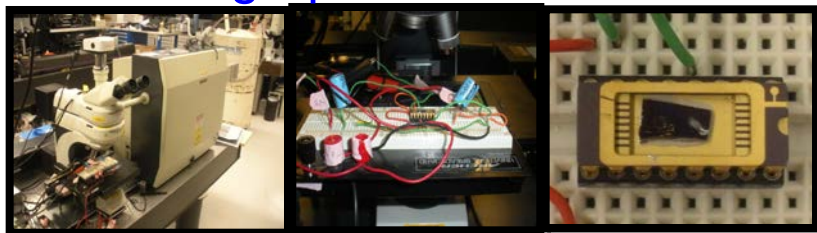
Liquid Carbon Source CVD graphene



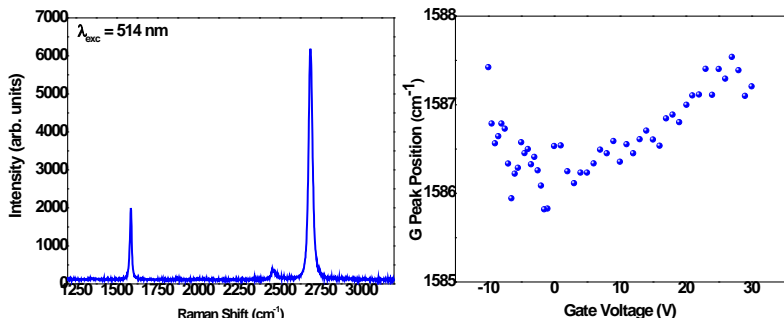
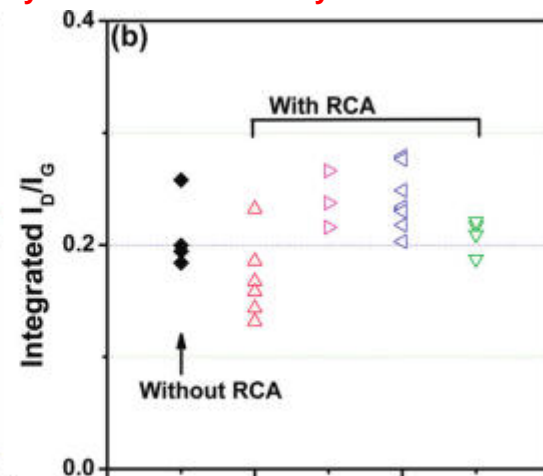
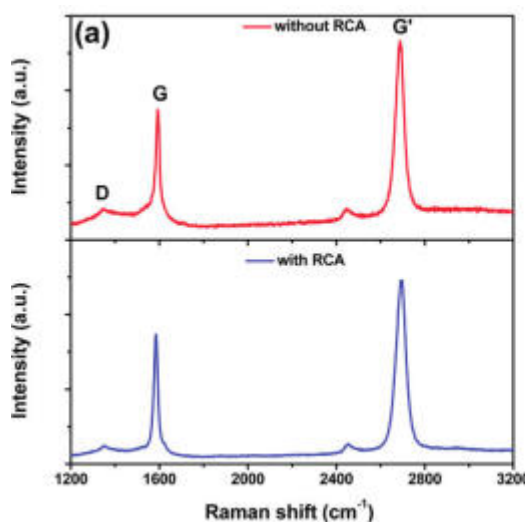
CVD graphene Transfer



Gated graphene transistors



RCA cleaning doesn't noticeably affect defect density.



Monitors doping level in graphene devices

ACS NANO 5: 11 9144

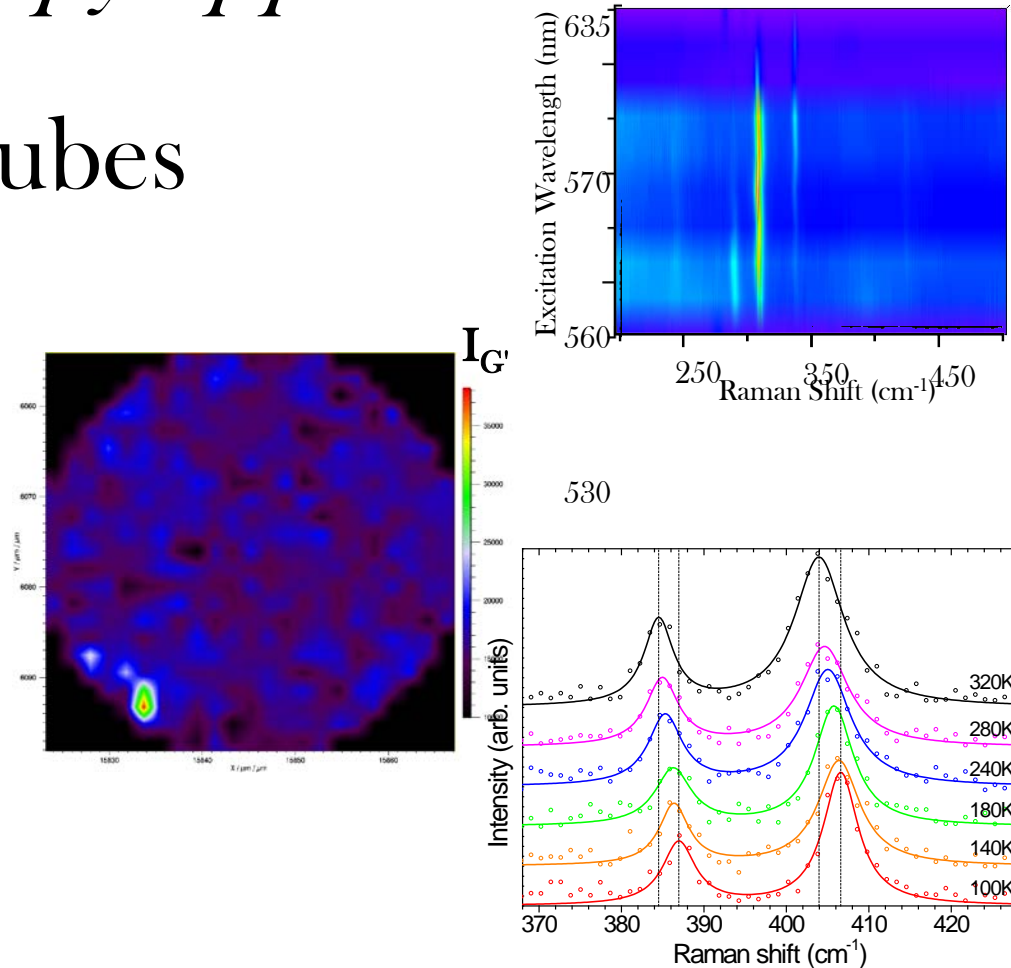
J. Mater. Chem., 2011, 21, 16057



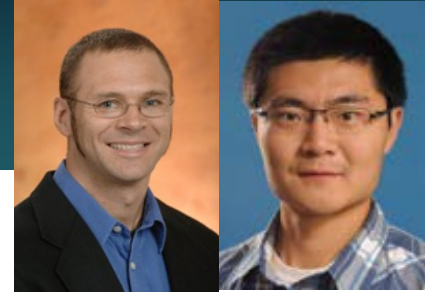
Outline

Raman spectroscopy applied to

- Carbon Nanotubes
- 2D Materials
- Graphene
- MoS_2



Introduction & Motivation



- Graphene stimulates interest in related layered materials, e.g., MoS₂:
single layer, **direct band gap** ~1.9eV
mobility $m <$ graphene

applications: transistors, photovoltaics, valleytronics

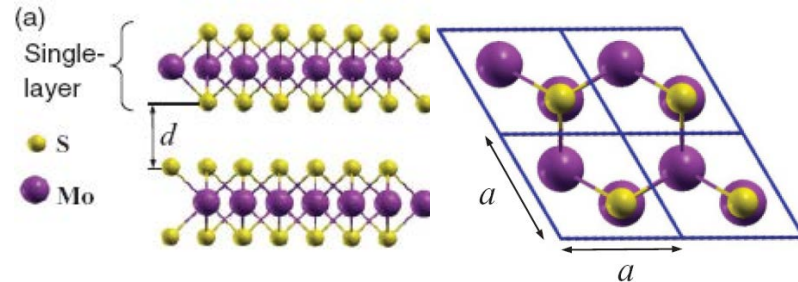
- MoS₂ structure: layered trigonal prismatic,

1L non-centrosymmetric P6m2 (D_{3h})

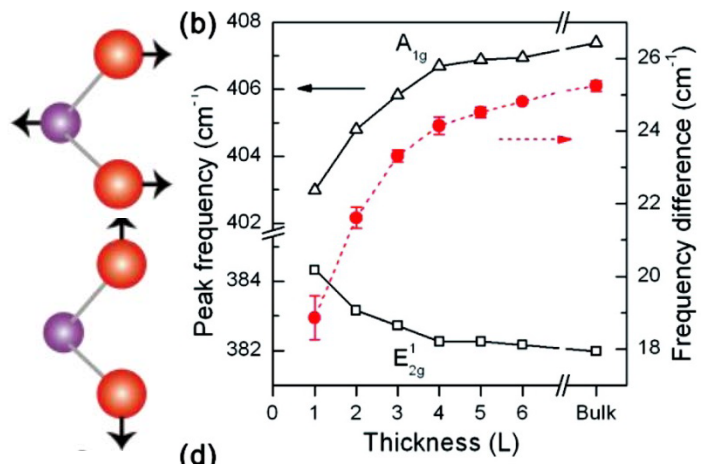
- Raman spectroscopic characterization of MoS₂

- two prominent Raman-active phonons symmetry E_{2g}¹ (in-plane) & A_{1g} (out-of-plane)
- quantifies layer#: peak difference

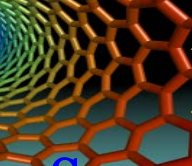
- Understanding of optical & thermal properties important for device applications



Molina-Sanchez *et al.*, PRB **84**, 155413 (2011)

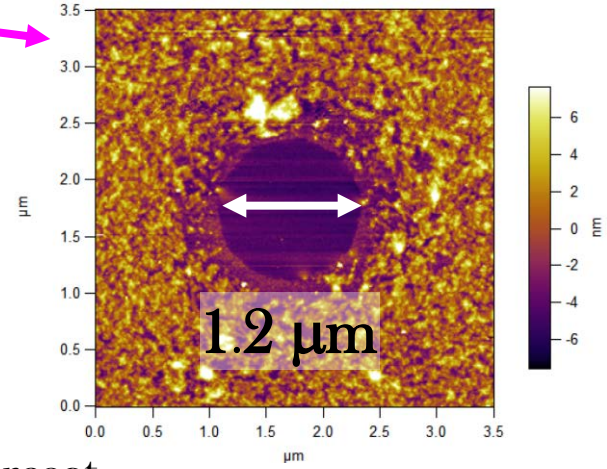
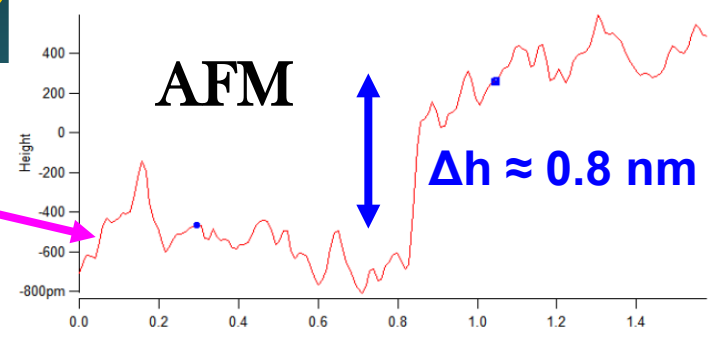
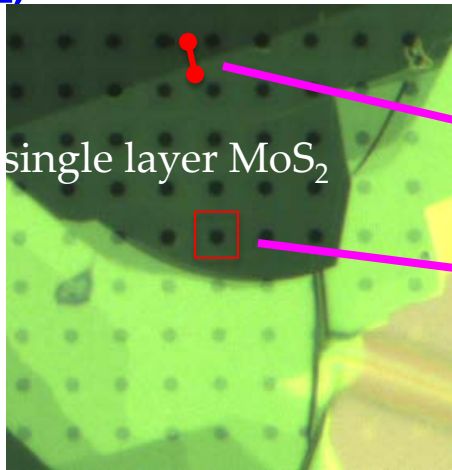
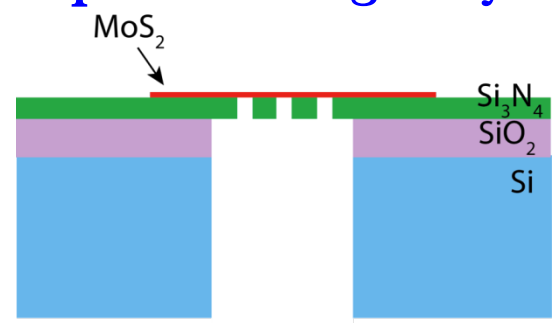


Lee *et al.*, ACSNano **4**, 2695 (2010)



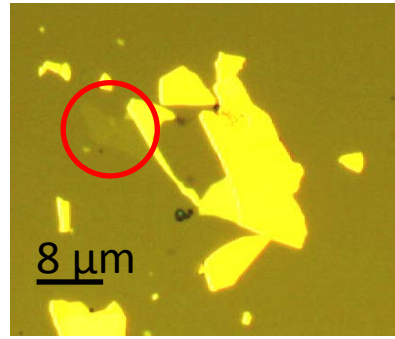
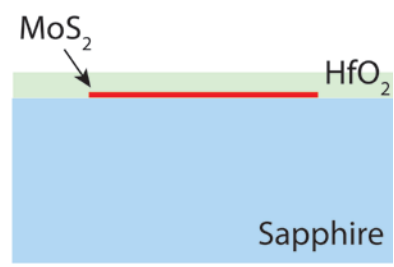
MoS₂ Monolayer Samples

Suspended single layer (1L)

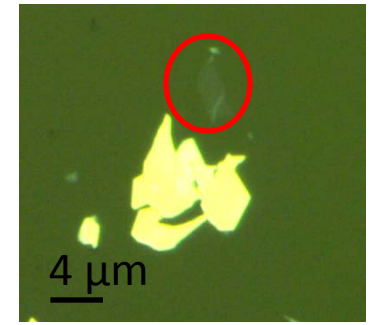
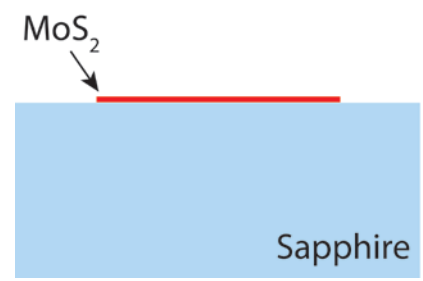


Substrate (Al₂O₃) supported

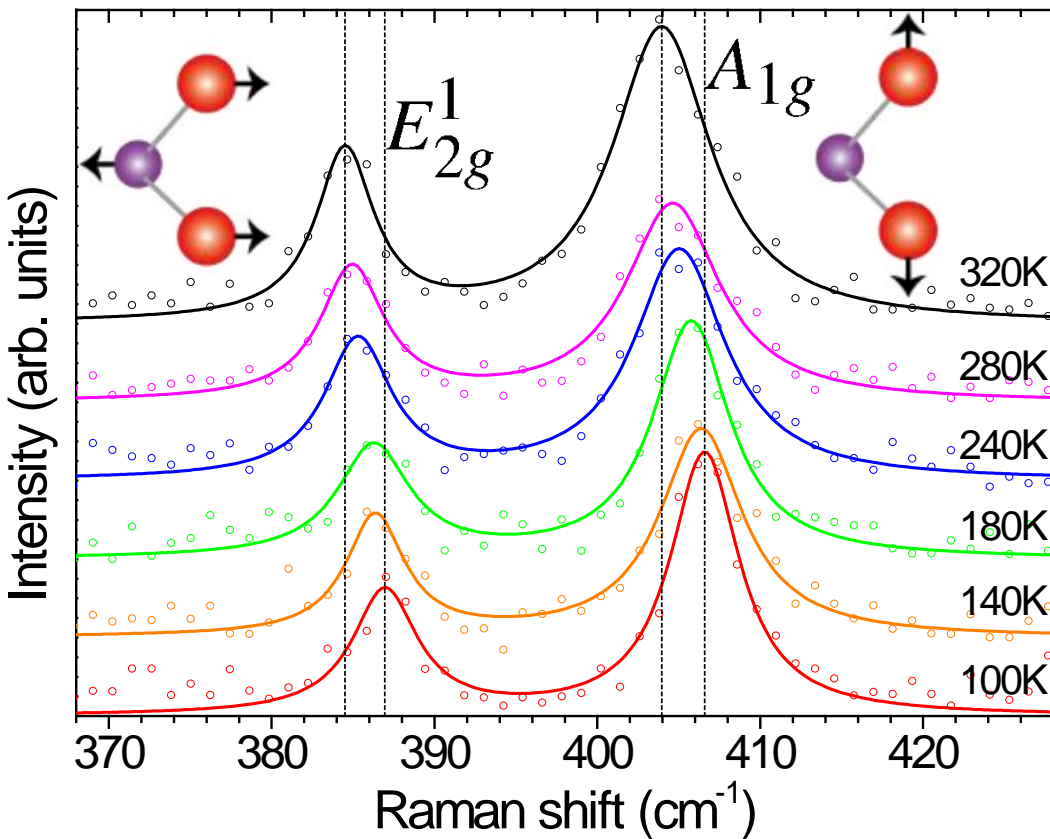
with HfO₂ overcoat



w/o HfO₂ overcoat



Temperature-Dependent Raman Spectra



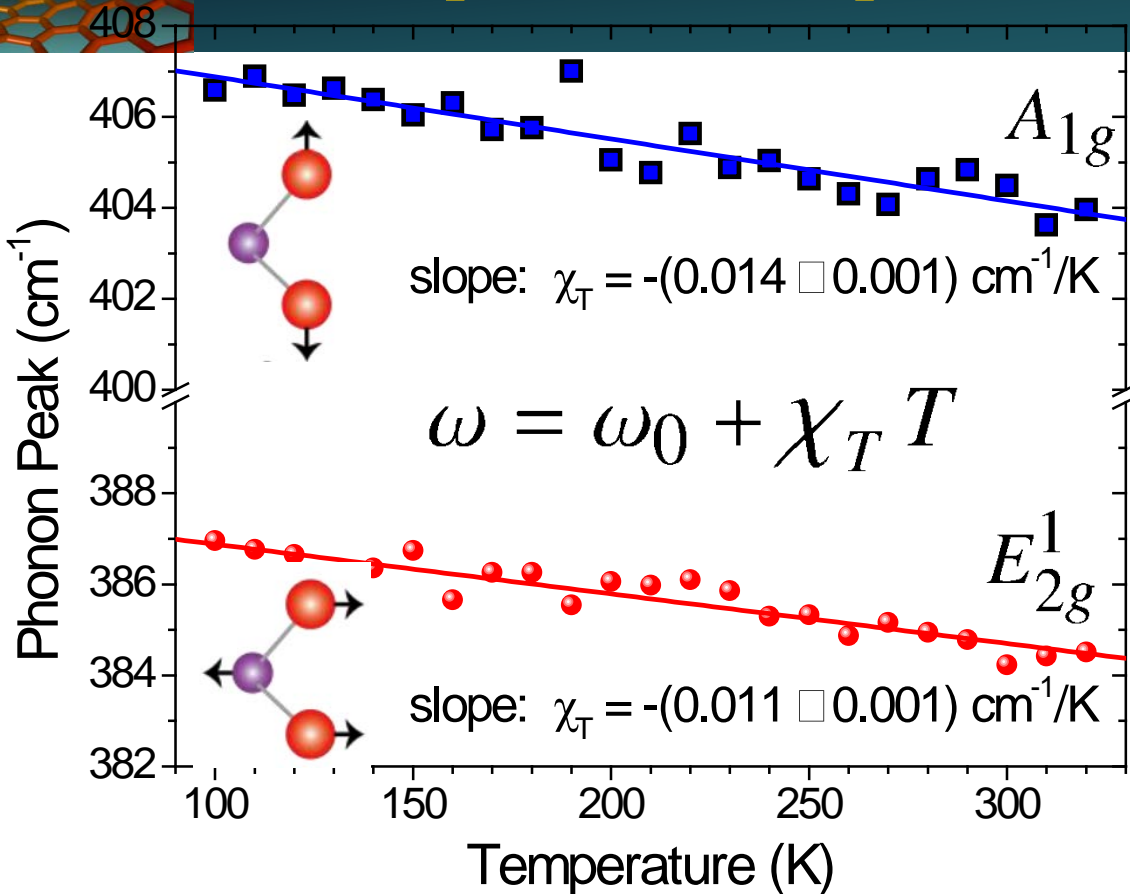
$\lambda_{\text{ex}} = 514.5 \text{ nm}$

$< 0.2 \text{ mW}$ (50X NA 0.55)

$\sim 1.2 \mu\text{m}$ diffraction-limited spot

- observe two prominent Raman-active phonons: E_{2g}^1 (in-plane) and A_{1g} (out-of-plane)
- phonons **soften** with **increasing temperature**
- low optical power (intensity) to minimize thermal effects, *e.g.*, avoid local heating & sample damage

Temperature-Dependent Phonon Peaks



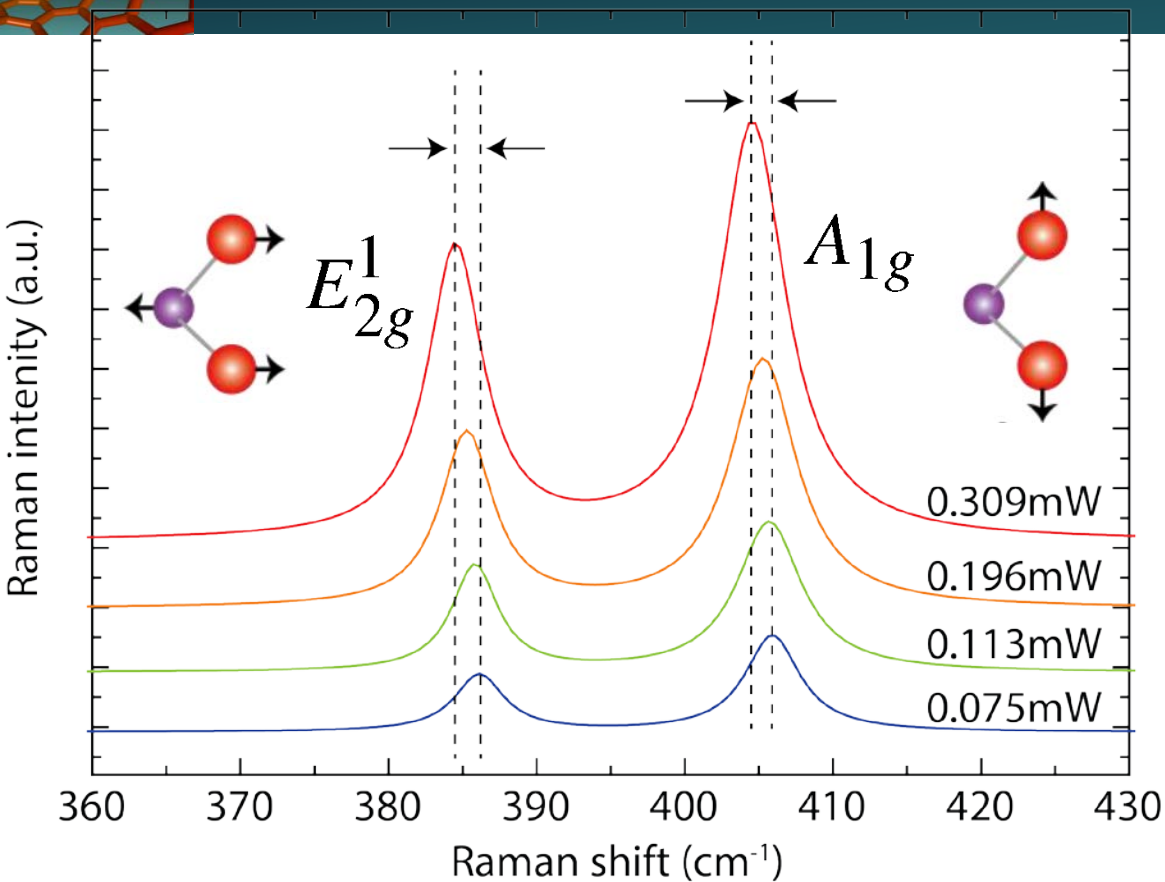
MoS ₂	χ_T (cm^{-1}/mW)	
	E_{2g}^1	A_{1g}
1L suspended	-0.011	-0.014

Graphene	χ_T (cm^{-1}/mW)	
	G-band E_{2g}	
1L suspended ¹	-0.016	

¹ Balandin *et al.*, *NL* **8**, 902 (2008)

- Phonon frequencies **soften linearly** with increasing temperature
- Anharmonic lattice potential \rightarrow phonon scattering, thermal expansion
- Extract linear temperature coefficient χ_T (cm^{-1}/K)
- A_{1g} slightly more sensitive to temperature change

Laser Power-Dependent Raman Spectra



room temperature

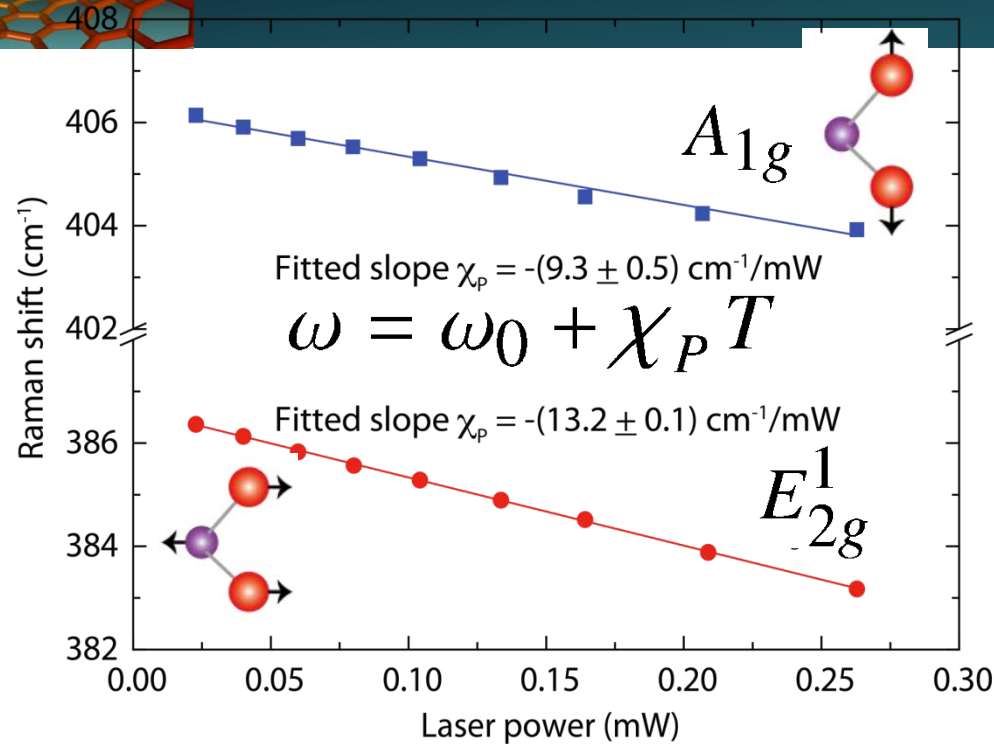
$\lambda_{\text{ex}} = 488 \text{ nm}$

100X NA 0.95

$\sim 0.7 \mu\text{m}$ diffraction-limited spot

- Room temperature measurement
- local heating softens phonon peak frequency
- sample damage for power $> 2\text{mW}$

Laser Power-Induced Phonon Peak Shifts



MoS ₂	χ_p (cm ⁻¹ /mW)	
	E _{2g} ¹	A _{1g}
1L suspended	-13.2	-9.3
1L supported ¹	-0.09	-0.40

[1] R. Yan *et al.*, arXiv:1211.4136

Graphene	χ_p (cm ⁻¹ /mW)
	G-band E _{2g}
1L suspended ²	-1.3
1L supported ³	-0.7

² Balandin *et al.*, Nano. Lett. **8**, 902 (2008)

³ Lee *et al.*, PRB **83**, 081419 (2011)

- Linear at low power, saturates above 0.3 mW (not shown)
- A_{1g} less sensitive to power
- substrate serves as heat sink
- 10x larger χ_p coefficient than graphene

Optical Absorption in Monolayer MoS₂

Thermal conductivity $\kappa = \frac{A}{2\pi t} \frac{\partial P}{\partial T}$

$$n_0 = 1 \text{ (suspended MoS}_2\text{)}$$

$$n_1 = 1 - 5i$$

$$n_2 = 1$$

Model suspended 1L with complex index of refraction $n_1 = 5 - i$ surrounded by air obtain transmittance T & reflectance R

$$\mathcal{T} = \left| \frac{t_{01}t_{12} e^{i\phi_1}}{1 - r_{10}^2 e^{2i\phi_1}} \right|^2$$

$$\mathcal{R} = \left| \frac{r_{01} (1 - e^{i2\phi_1})}{1 - r_{10}^2 e^{i2\phi_1}} \right|^2$$

$$t_{01} = \frac{E_t}{E_i}$$

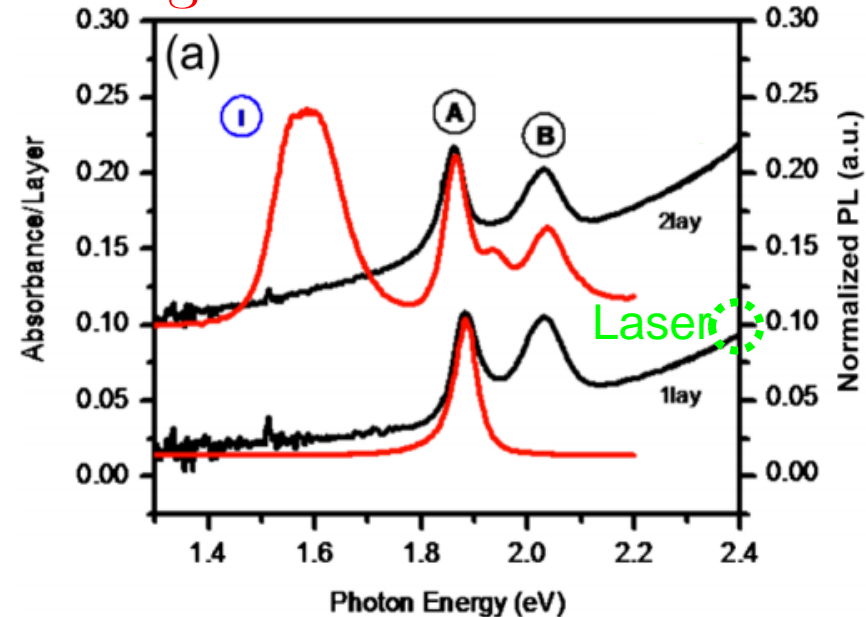
$$r_{01} = \frac{E_r}{E_i}$$

$$\phi_1 = 2\pi \tilde{n}_1 \nu d_1$$

absorbance: $A = 1 - (R + T) = 0.09$
 use this for determining incident laser power absorbed by sample

Beal & Hughes, JPC: Sol State Phys (1979)

agrees with measurement



Mak *et al.*, PRL **105**, 136805 (2010)

Estimating Thermal Conductivity

Thermal
conductivity

$$\kappa = \frac{A}{2\pi t} \frac{\partial P}{\partial T}$$

Rewrite κ in terms of phonon shifts linear temperature & power coefficients, χ_T & χ_P

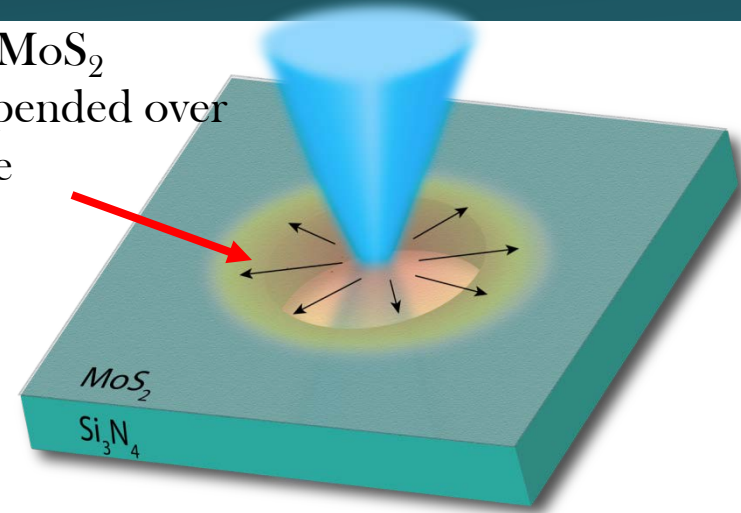
$$\kappa = \frac{A}{2\pi t} \frac{\partial P}{\partial \omega} \frac{\partial \omega}{\partial T} = \frac{A}{2\pi t} \frac{\left(\frac{\partial \omega}{\partial T}\right)}{\left(\frac{\partial \omega}{\partial P}\right)}$$

$$\kappa = \frac{A}{2\pi t} \frac{\chi_T}{\chi_P}$$

thermal conductivity κ
from measured χ values

* A_{1g} dominates κ in MoS_2

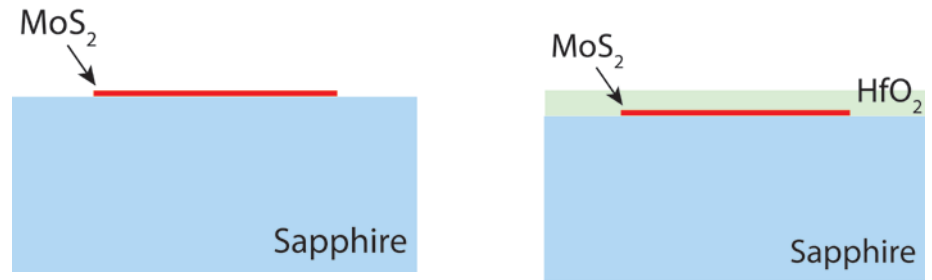
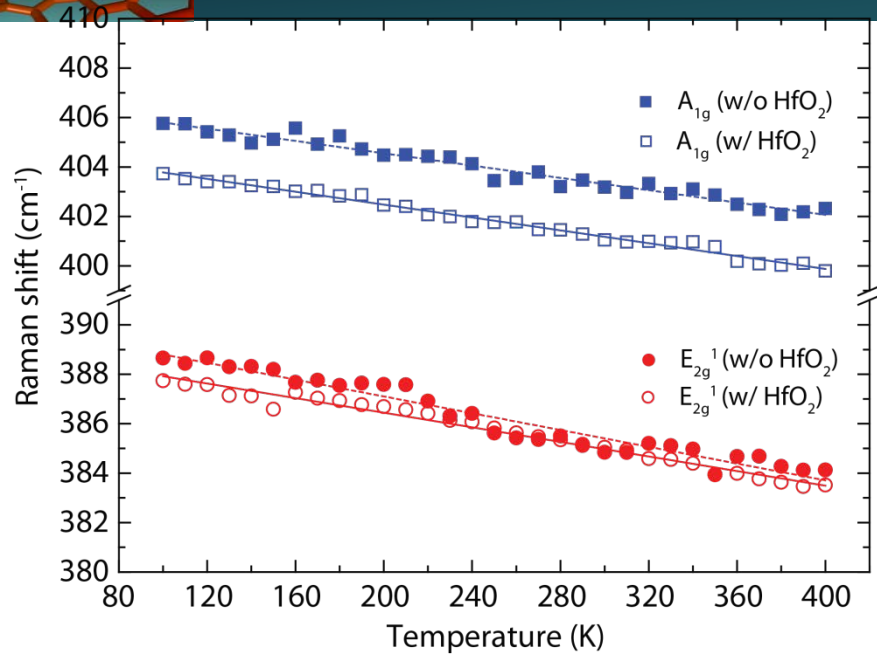
1L MoS_2
suspended over
hole



Suspended single layer	κ W/(m K)
MoS_2	27 +/- 20% *
graphene ¹	5000

¹ Balandin *et al.*, Nano Lett. **8**, 902 (2008).

Substrate-Supported 1L MoS₂



- Al₂O₃ & HfO₂ similar thermal expansion & larger than bulk MoS₂ → tensile strain

Sapphire : 7.3x10⁻⁶/K, HfO₂: 6.7x10⁻⁶/K

Bulk MoS₂ (in plane): 4.9x10⁻⁶/K

- HfO₂ induces A_{1g} shift → electronic doping^{1,2}
- Consistent with theoretical prediction: A_{1g} more sensitive to el-ph coupling¹

1. B. Chakraborty et al., PRB 85, 161403(R) (2012).

2. R. Yan et al., arXiv:1211.4136.

MoS ₂	χ _T (cm ⁻¹ /mW)	
	E _{2g} ¹	A _{1g}
w/ HfO ₂	-0.017 >	-0.013
w/o HfO ₂	-0.015 >	-0.013
suspended	-0.011 <	-0.014

Thermal expansion: Sapphire : 7.3x10⁻⁶/K

HfO₂: 6.7x10⁻⁶/K

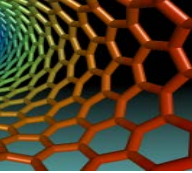
Bulk MoS₂ (in plan): 4.9x10⁻⁶/K



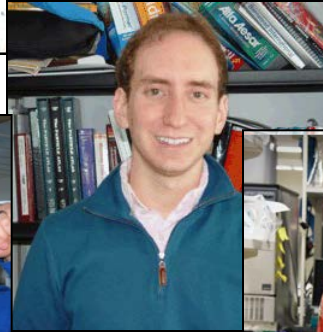
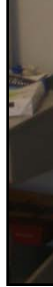
Conclusions

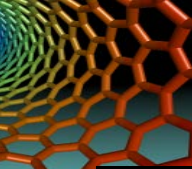
Raman continues to be a novel
characterization methods for
nanoelectronics

Thank you for you attention....



Thanks the people who do the work

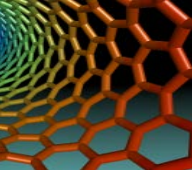




Problem and Solution

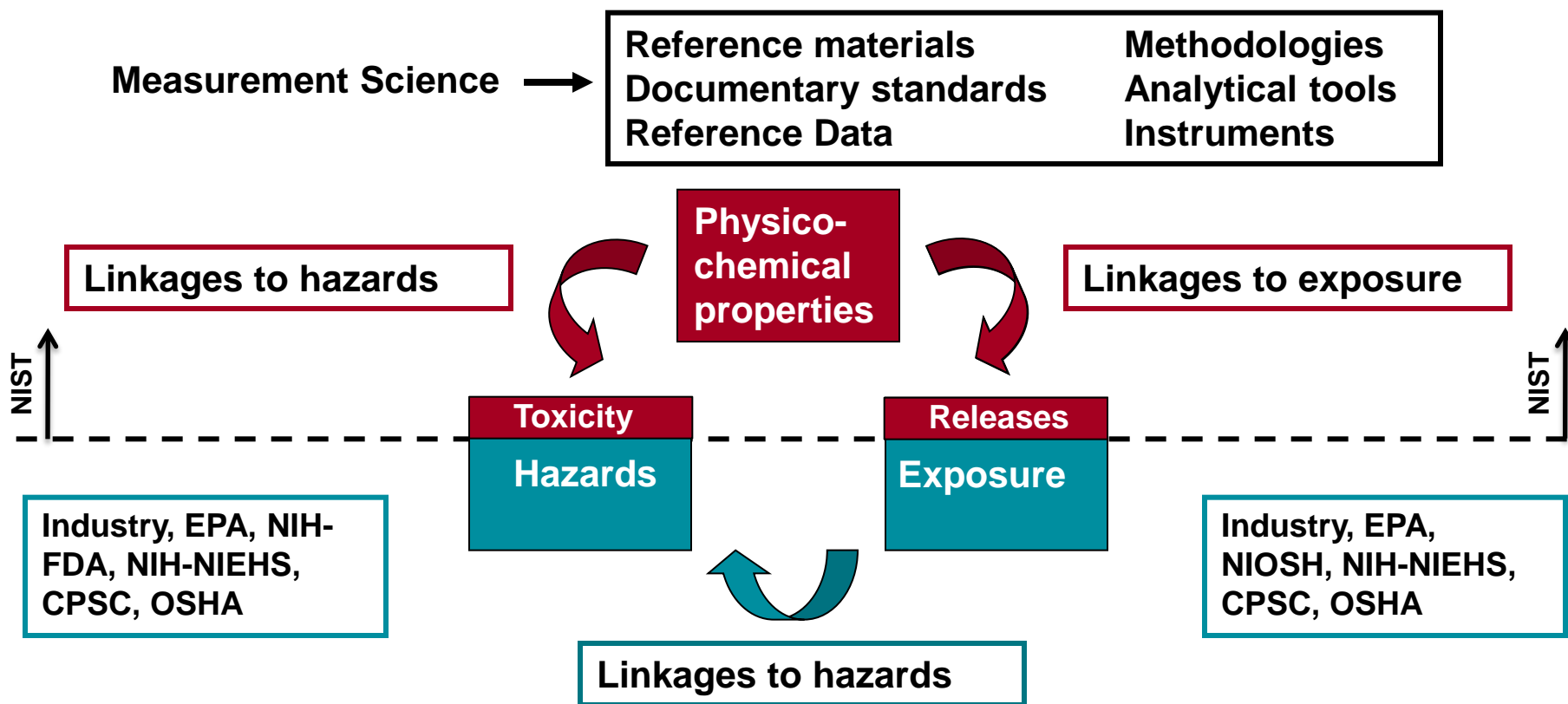
Nanomaterials and products that incorporate nanomaterials pose *unknown risks* throughout all stages of their life cycles, from initial sourcing through manufacture, use, disposal or recycling, and ultimate fate.

Sets of accurate data for physico-chemical properties, hazards, and exposure to enable science-based, lifecycle risk assessment and risk management of nanomaterials and products that incorporate them.



NIST Role in the Solution

Create and disseminate critical measurement solutions for determining key *physico-chemical and toxicological properties of nanomaterials and release of nanomaterials* throughout the full life cycles of key nanomaterials and products containing these nanomaterials.



Nano-EHS Technical Program

Measurement Science →

Reference materials
 Documentary standards
 Reference Data

Methodologies
 Analytical tools
 Instruments

Static Physico-chemical Properties*

Concentration of neutral and ionic species of key nanomaterials

Surface attributes of key nanomaterials:*

- Surface area
- Composition, location, and degree of coverage of surface species
- Morphology from the atomic to cellular scales
- Surface charge

**Controlled dispersion is critical for all measurements*

Dynamic Physico-chemical Properties*

Transformation processes for key nanomaterials:*

- Aggregation and agglomeration
- Ionic dissolution
- Adsorption of organic matter and bioconstituents
- Electron transport, e.g., oxidation
- Attachment of nanomaterials to surfaces

Transport

Fate: equilibrium state, concentration, and distribution

**In relevant media: air, water, soil, sediment, and biological matrices*

Toxicological Properties*

Biomarkers and other indicators of toxicological response

Genotoxicity assays

Mechanistic cytotoxicity assays

Physico-chemical properties

Toxicity

Hazards

Releases

Exposure

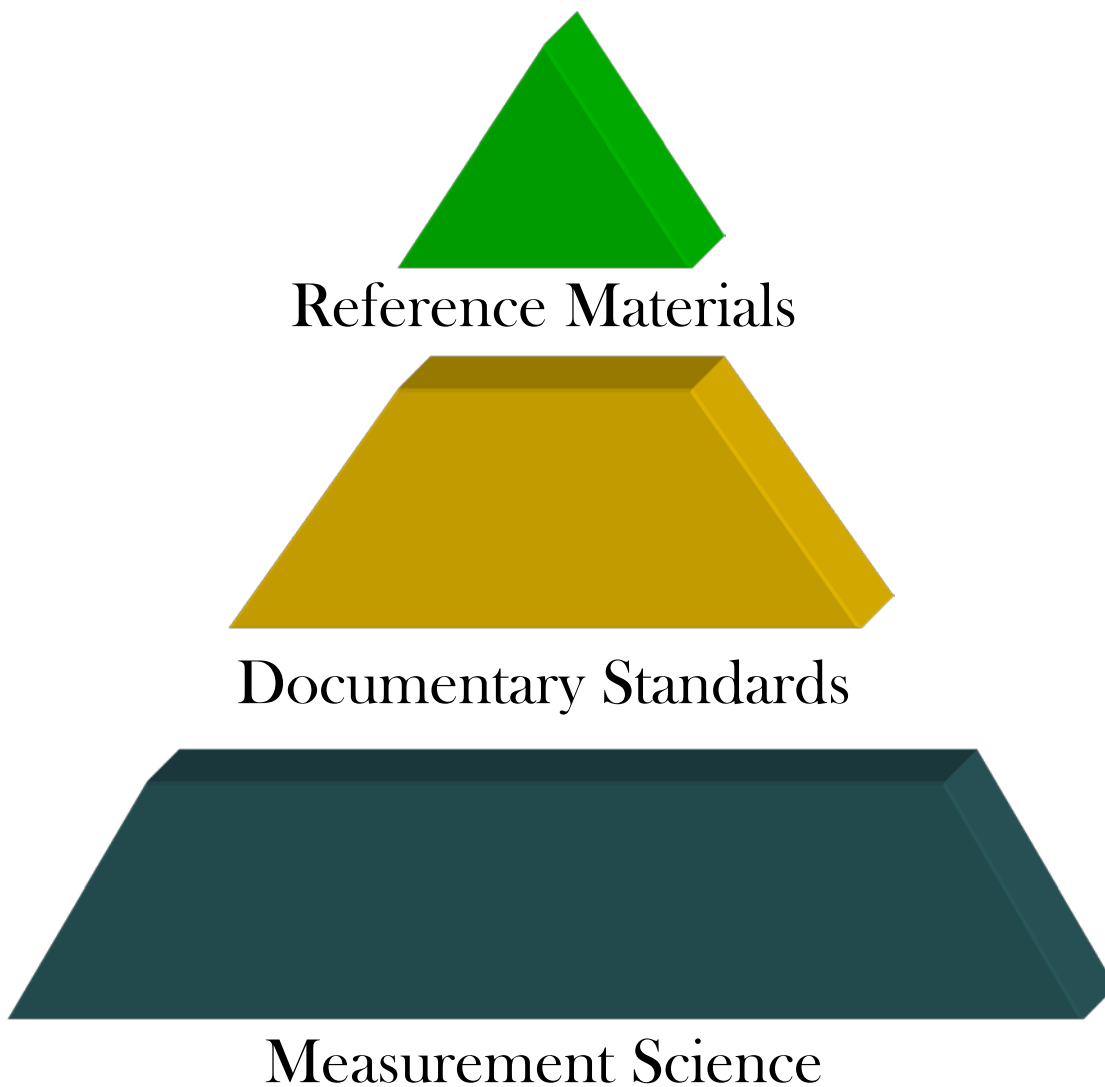
Exposure effects*

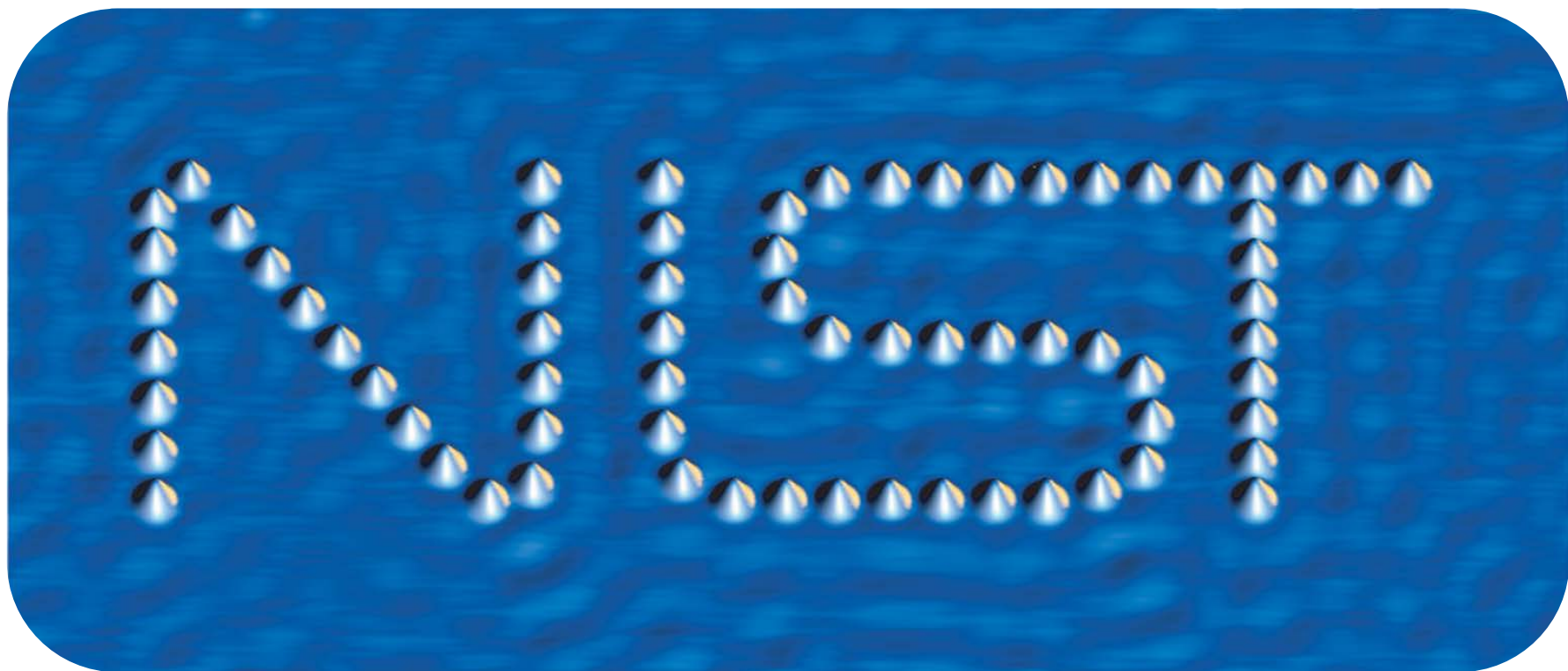
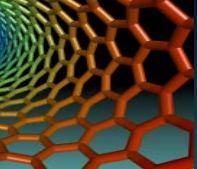
Release of key nanomaterials from products

- Incineration
- Wear
- Chemical reactions

Emissions from manufacturing processes

Optimal Approach





Thank you!!